

Femto-UP 2020-21 School

Femtosecond Pulse Generation

Adeline Bonvalet

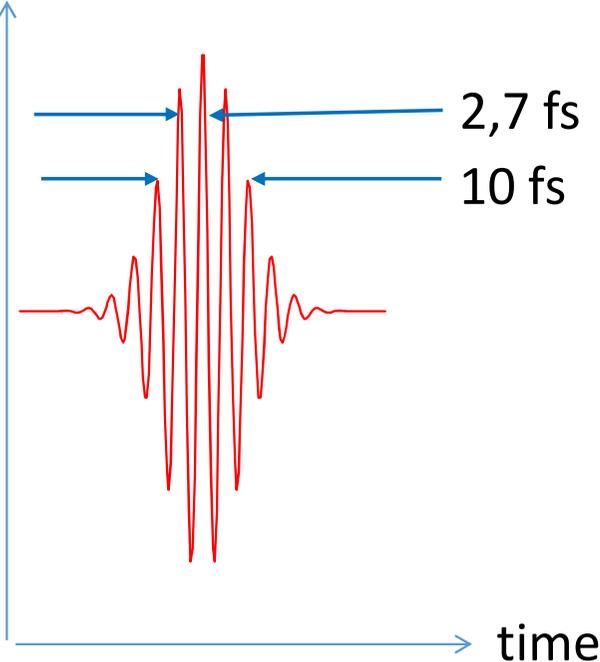
Laboratoire d'Optique et Biosciences

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91128, Palaiseau, France

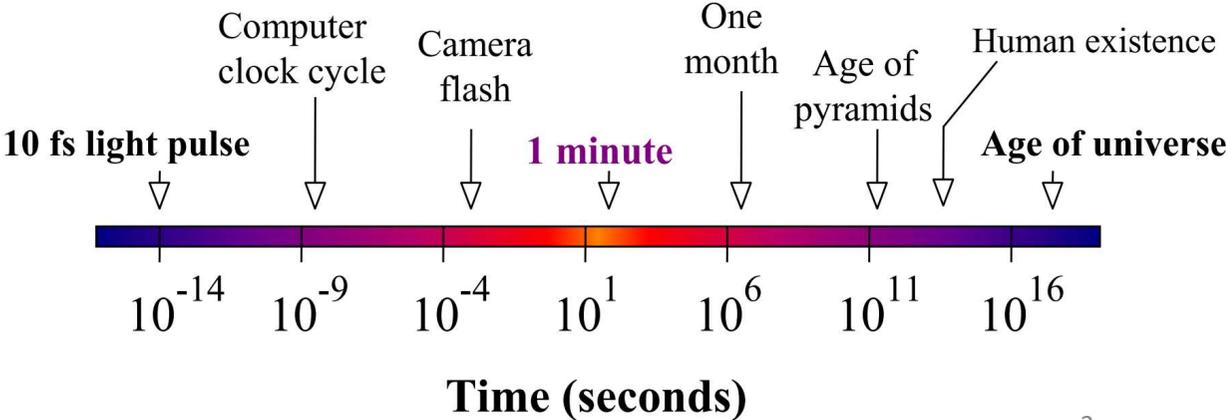


Definitions

Electric field of a 10-fs 800-nm pulse

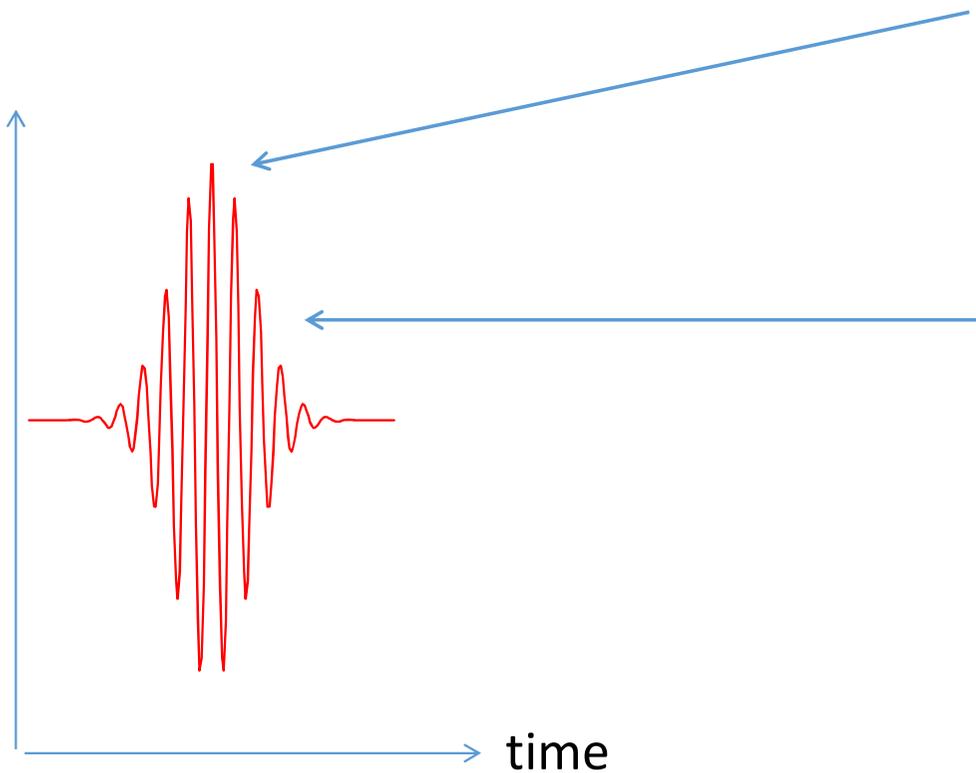


nano	↓	10^{-9}	sec
pico		10^{-12}	
femto		10^{-15}	
atto		10^{-18}	



Many properties

Electric field of a 10-fs 800-nm pulse



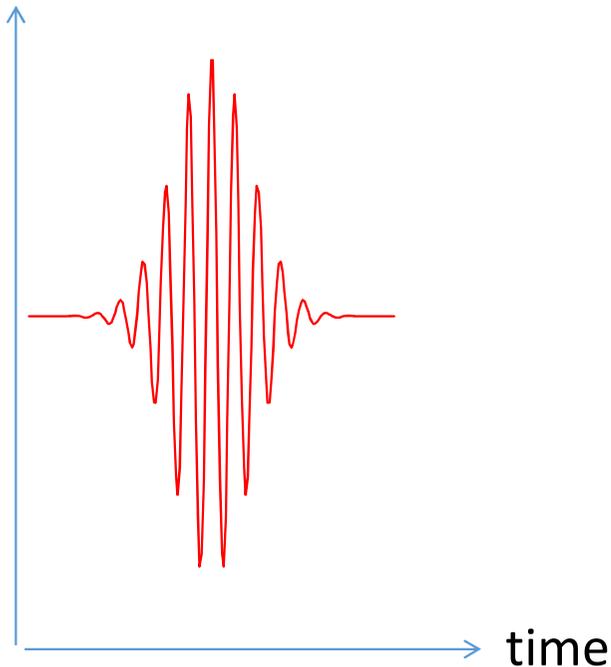
High peak power
(Energy / Duration)

Ultrashort Duration

Spectral Properties
(Frequency Comb)

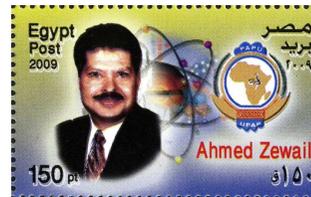
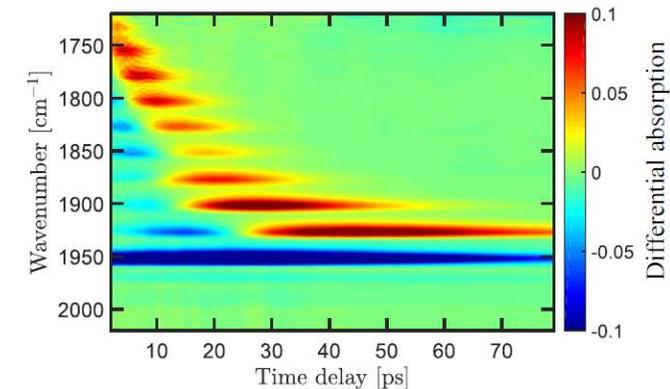
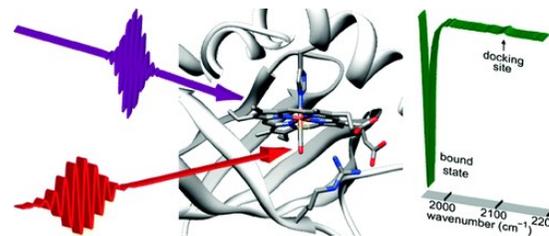
Time-resolved spectroscopy

Electric field of a 10-fs 800-nm pulse



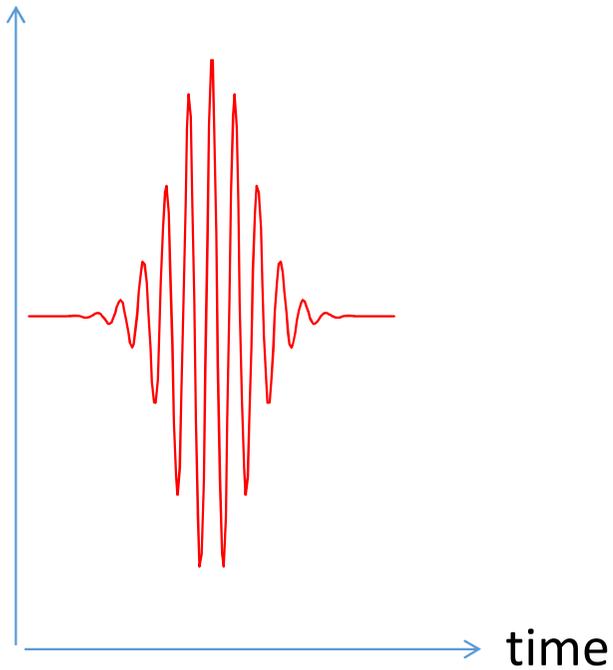
Ultrashort Duration

Time-resolved spectroscopy
Direct observation of ultrafast motions



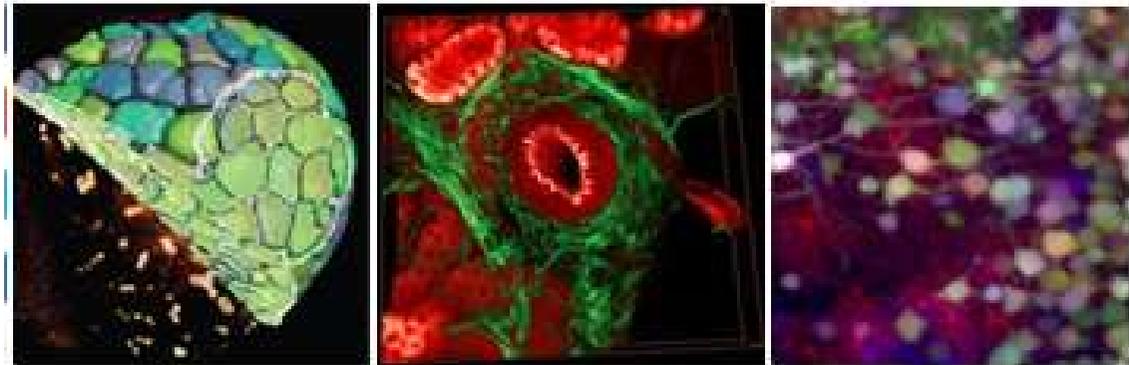
Ahmed Zewail, Nobel Prize in chemistry 1999, femtochemistry

Electric field of a 10-fs 800-nm pulse



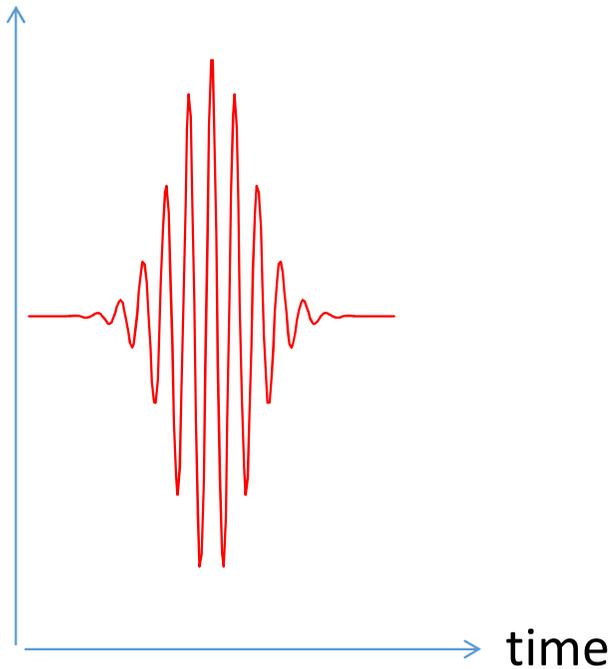
High peak power
(Energy / Duration)

Nonlinear microscopy



Material processing

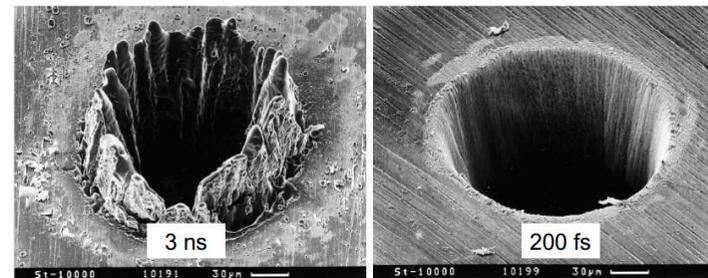
Electric field of a 10-fs 800-nm pulse



High peak power
(Energy / Duration)

Laser matter interaction

Drilling, cutting, etching,...



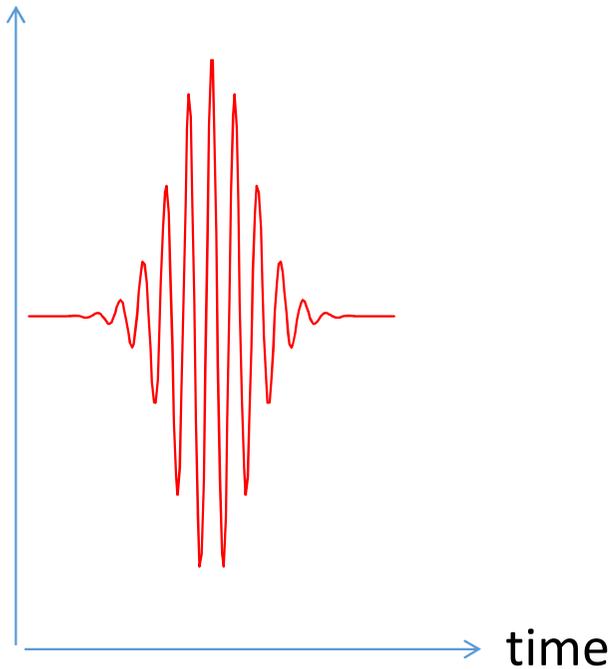
B. Chichkov et al, *Appl. Phys. A*, 63, 109 (1996)



Areas of applications : aeronautics, electronics, medical, optics...

Light matter interaction

Electric field of a 10-fs 800-nm pulse



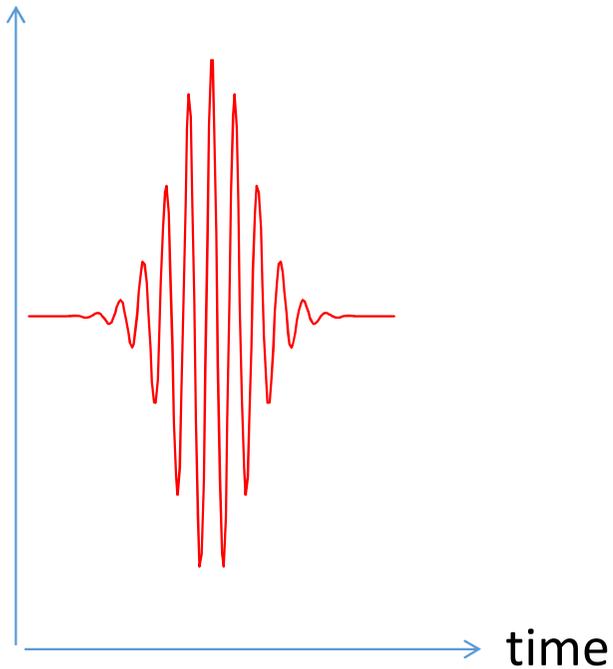
High peak power
(Energy /Duration)

Ability to reach extreme conditions
(amplified system)

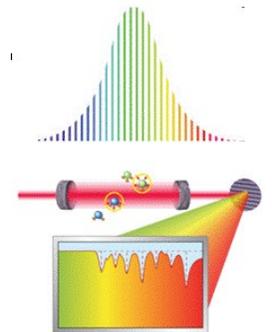
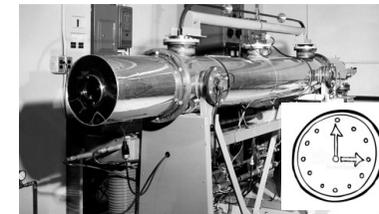
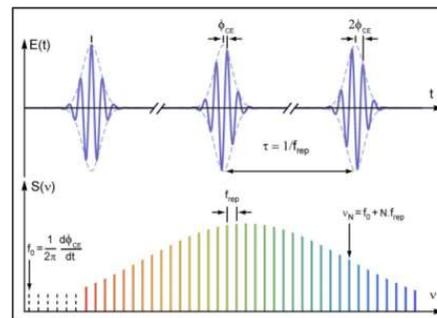
Applications : Sources of intense particles
beams, X-rays, high energy density science,
laboratory astrophysics ...



Electric field of a 10-fs 800-nm pulse



Spectral Properties
(Frequency Comb)



J.L. Hall



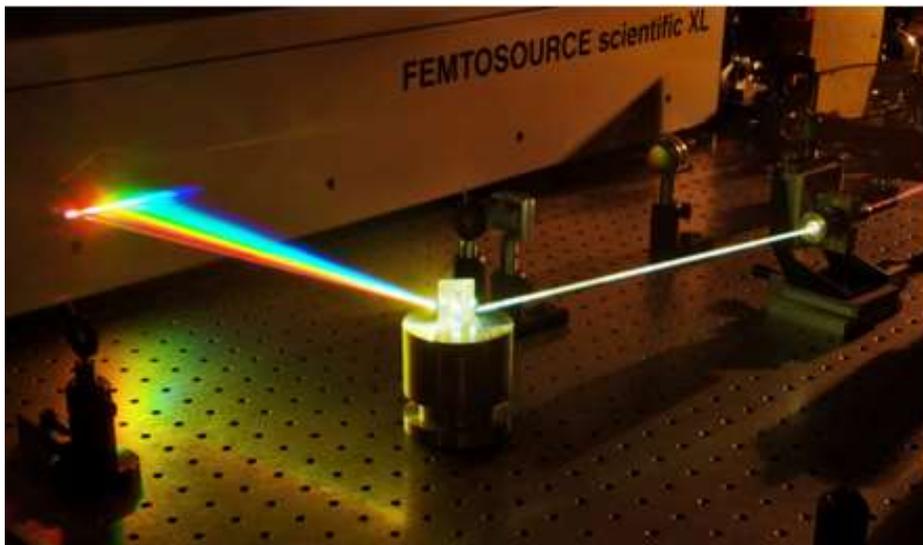
T.W. Hänsch

Nobel Prize 2005
"for their contributions to the development of laser-based precision spectroscopy, including the optical frequency comb technique."

Introduction

1. Description of ultrashort light pulses
2. Generation of femtosecond laser pulses via mode locking
3. Femtosecond oscillator technology

Introduction



© Manuel Joffre

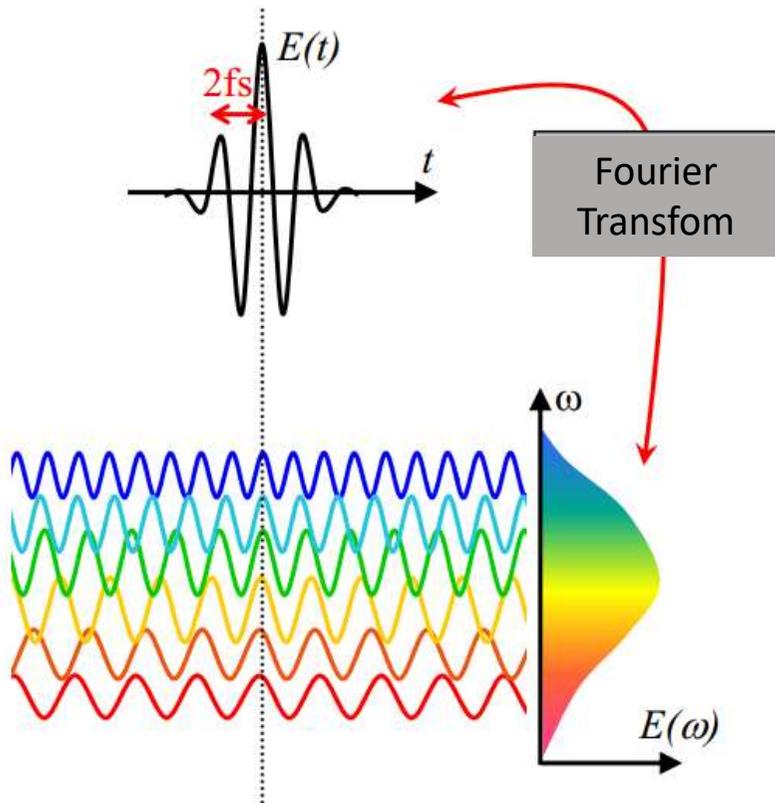
Ultrashort pulse = broad spectrum



What makes the difference between white light and femtosecond pulses ?

Definitions : Electric fields

$E(t)$ Real electric field



Ultrashort pulse

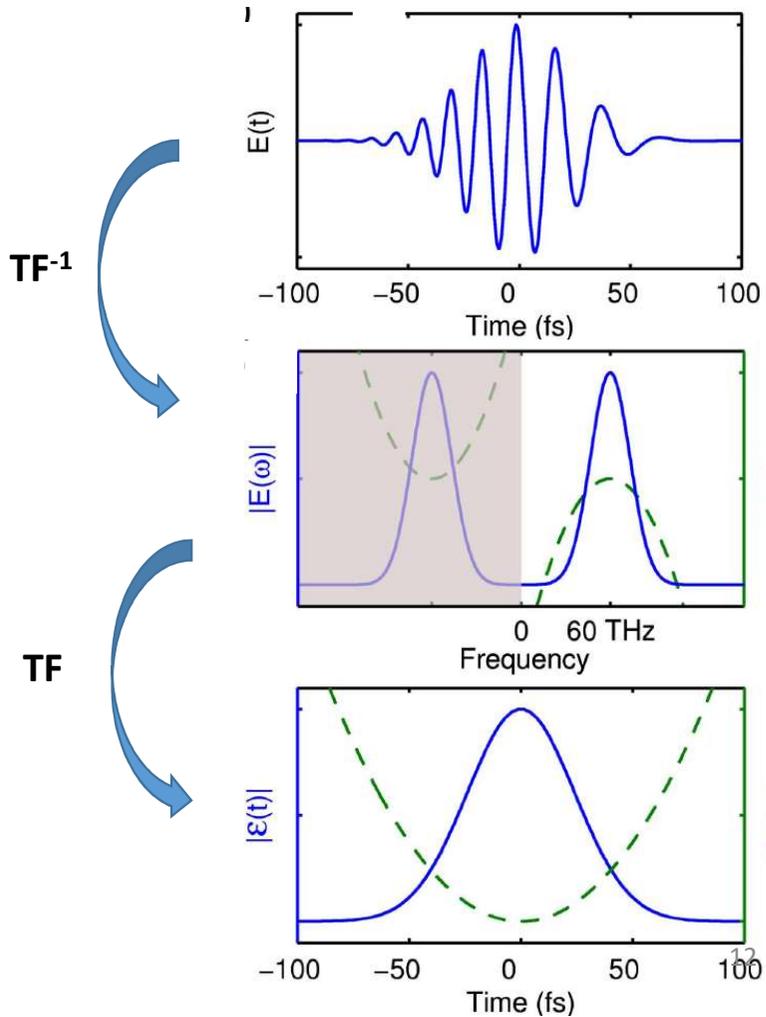
=

sum of monochromatic waves

$$E(t) = \int_{-\infty}^{\infty} E(\omega) \exp(-i\omega t) \frac{d\omega}{2\pi} = TF[E(\omega)]$$

$$E(\omega) = \int_{-\infty}^{\infty} E(t) \exp(i\omega t) dt = TF^{-1}[E(t)]$$

Definitions : Complex electric fields



Real electric field

Complex spectral field

$$\varepsilon(\omega) = |\varepsilon(\omega)| \exp(i\phi(\omega))$$

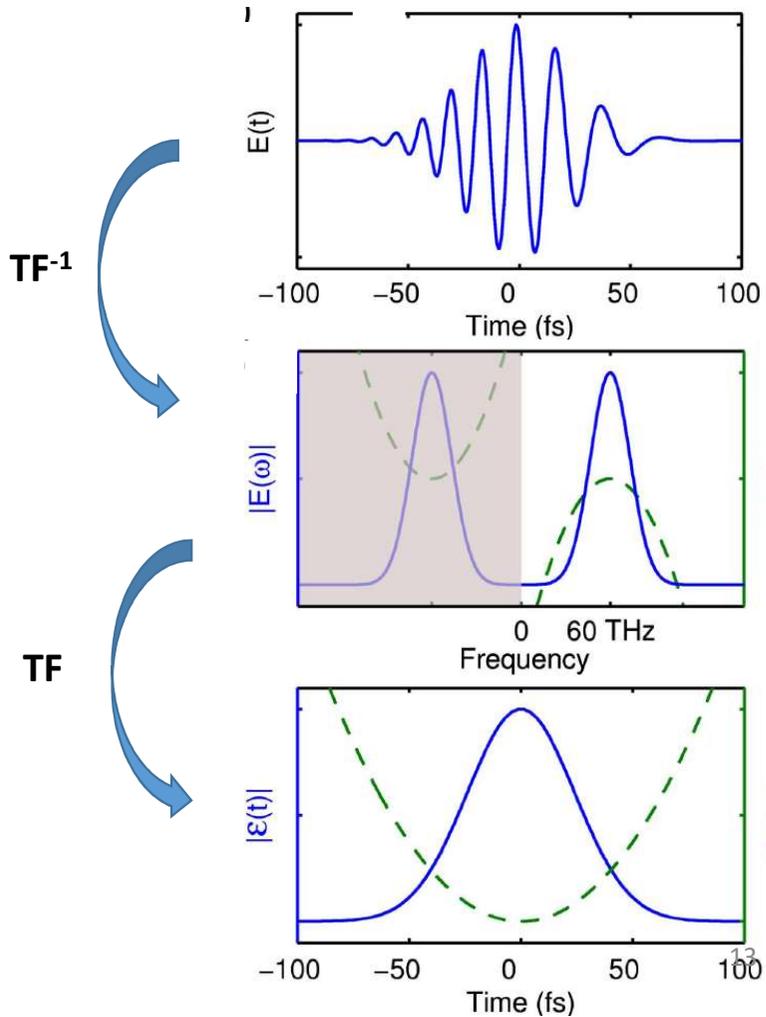
Spectral phase

Complex temporal field

$$\varepsilon(t) = |\varepsilon(t)| \exp(i\phi(t))$$

Temporal phase

Definitions : Complex electric fields



Real electric field

Complex spectral field

$$\varepsilon(\omega) = |\varepsilon(\omega)| \exp(i\phi(\omega))$$

Complex temporal field

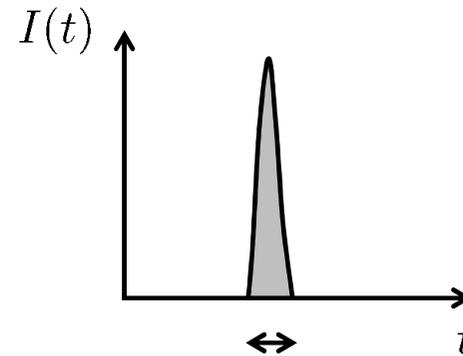
$$\varepsilon(t) = |\varepsilon(t)| \exp(i\phi(t))$$

$$\varepsilon(t) = TF(\varepsilon(\omega))$$

Definitions : Intensity

Temporal Intensity

$$I(t) = n \frac{\epsilon_0 c}{2} |\mathcal{E}(t)|^2$$

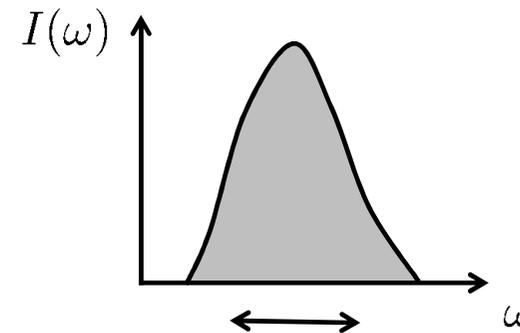


Time width

$$\Delta t = \sqrt{\langle (t - t_0)^2 \rangle}$$

Spectral Intensity

$$I(\omega) = n \frac{\epsilon_0 c}{2} |\mathcal{E}(\omega)|^2$$



Spectral width

$$\Delta \omega = \sqrt{\langle (\omega - \omega_0)^2 \rangle}$$

$$\Delta t \Delta \omega \geq \frac{1}{2}$$

Short pulse = broad spectrum

Gaussian pulse

Temporal field

$$\mathcal{E}(t) = \underbrace{\exp\left(-\frac{t^2}{2a^2}\right)}_{\text{Gaussian envelope}} \underbrace{\exp(-i\omega_0 t)}_{\text{Carrier wave}}$$

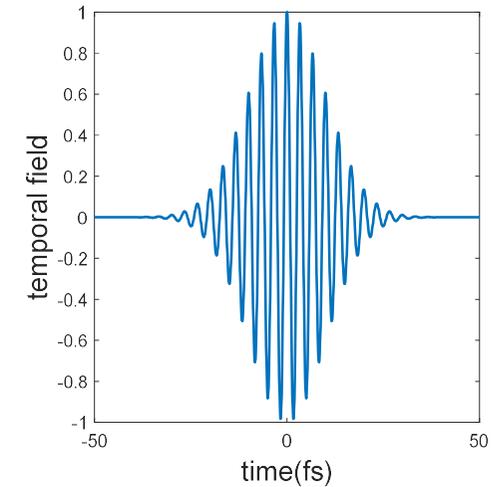
FT⁻¹ $TF^{-1}(f(t)g(t)) = \frac{1}{2\pi} f(\omega) \otimes g(\omega)$

Spectral field

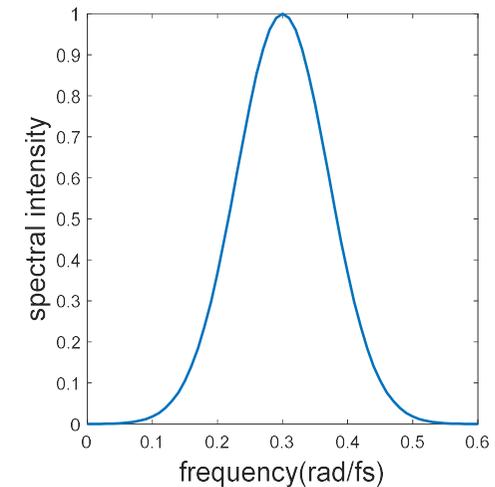
$$\mathcal{E}(\omega) = a\sqrt{2\pi} \exp\left(-\frac{a^2}{2}(\omega - \omega_0)^2\right)$$

Gaussian envelope centered on the carrier frequency

Temporal field



Spectral field



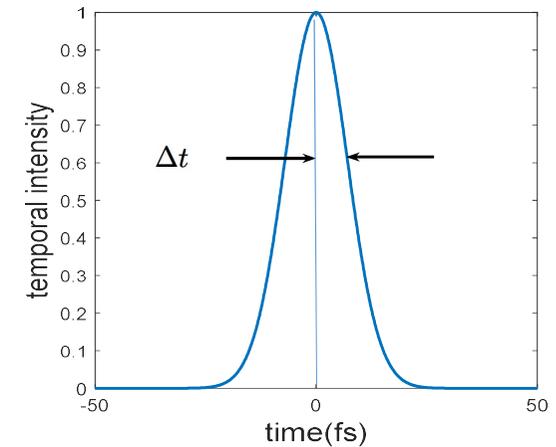
Gaussian pulse

Temporal intensity

$$I(t) = \exp\left(-\frac{t^2}{a^2}\right)$$

RMS width

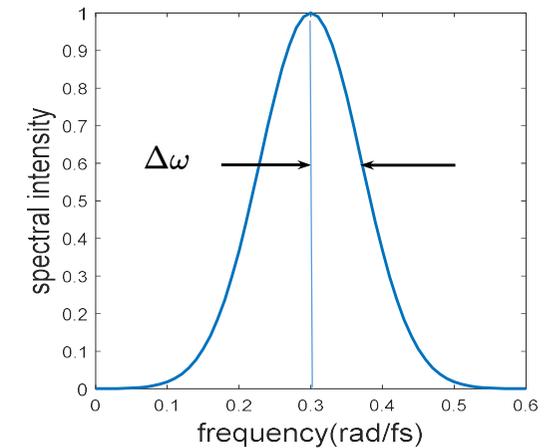
$$\Delta t = a/\sqrt{2}$$



Spectral intensity

$$I(\omega) = \exp(-a^2(\omega - \omega_0)^2)$$

$$\Delta\omega = 1/a\sqrt{2}$$



Gaussian pulse

Temporal intensity

$$I(t) = \exp\left(-\frac{t^2}{a^2}\right)$$

RMS width

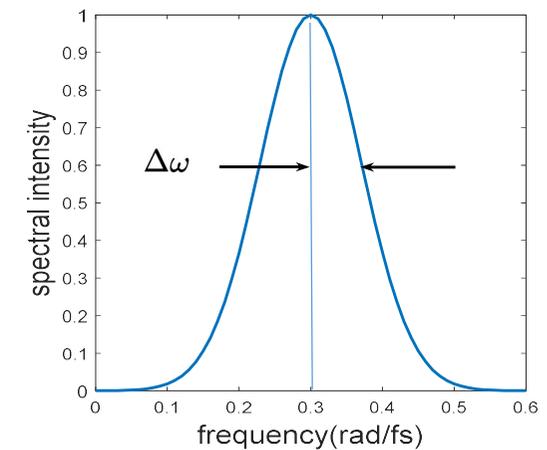
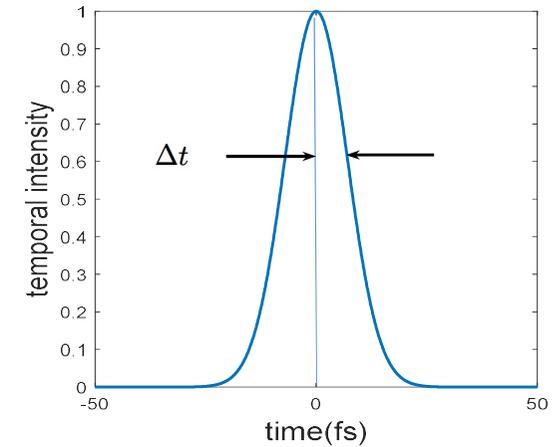
$$\Delta t = a/\sqrt{2}$$

$$\Delta t \Delta \omega = 1/2$$

Spectral intensity

$$I(\omega) = \exp(-a^2(\omega - \omega_0)^2)$$

$$\Delta \omega = 1/a\sqrt{2}$$



Gaussian pulse

Temporal intensity

$$I(t) = \exp\left(-\frac{t^2}{a^2}\right)$$

RMS width

$$\Delta t = a/\sqrt{2}$$

$$\Delta t \Delta \omega = 1/2$$

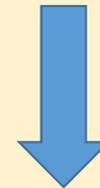
Spectral intensity

$$I(\omega) = \exp(-a^2(\omega - \omega_0)^2)$$

$$\Delta \omega = 1/a\sqrt{2}$$

$$\Delta t \Delta \omega = 1/2$$

The uncertainty limit is only reached for Gaussian pulses



for a given spectral width, the Gaussian pulse has the shortest possible duration

Gaussian pulse

Temporal intensity

$$I(t) = \exp\left(-\frac{t^2}{a^2}\right)$$

FWHM

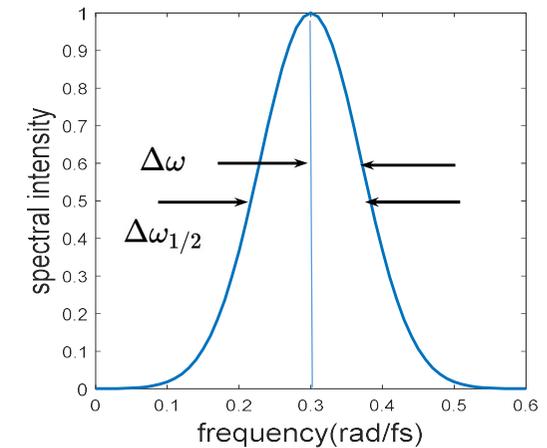
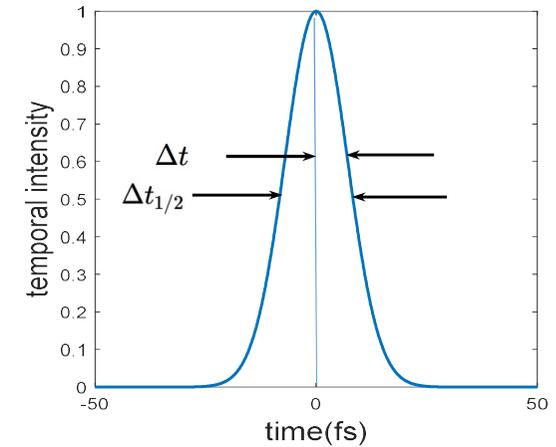
Full Width at Half Maximum

$$\Delta t_{1/2} = \sqrt{8\ln 2}\Delta t = 2.355\Delta t$$

$$\Delta t_{1/2}\Delta\omega_{1/2} = 4\ln 2$$

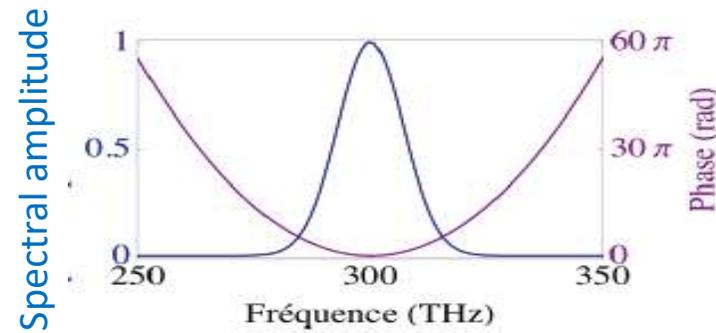
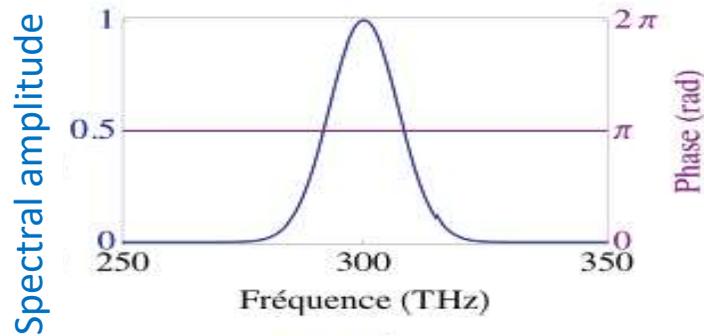
Spectral intensity

$$I(\omega) = \exp(-a^2(\omega - \omega_0)^2)$$



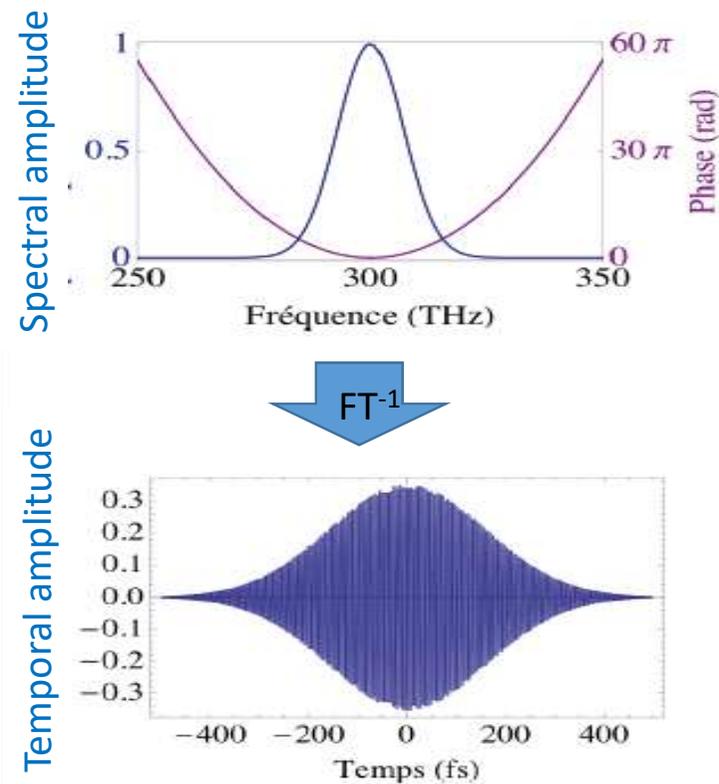
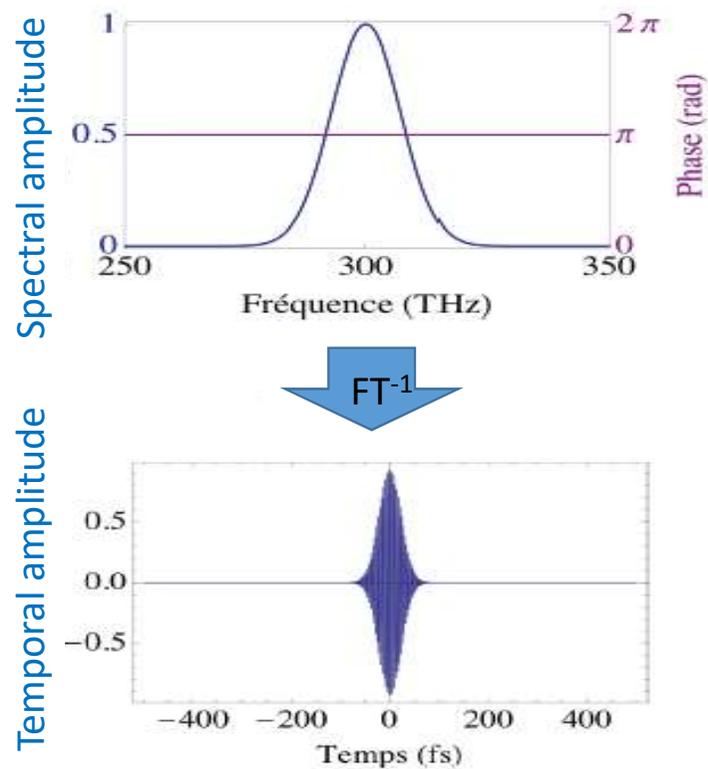
For $\lambda=1 \mu\text{m}$ Pulse duration = 100 fs / Spectral bandwidth = 14,6 nm

Temporal profile and spectral phase



$$\varepsilon(\omega) = |\varepsilon(\omega)| \exp(i\varphi(\omega))$$

Temporal profile and spectral phase



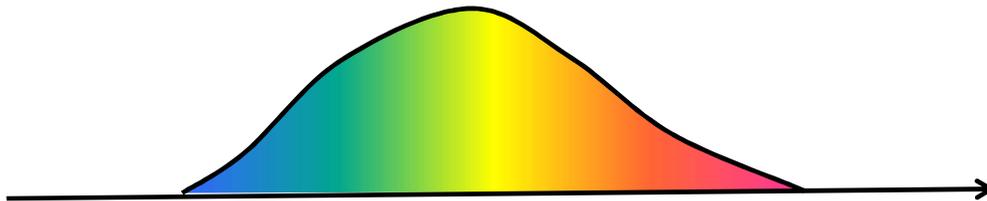
Effects of the spectral Phase

$$\mathcal{E}(\omega) = |\mathcal{E}(\omega)| \exp(i\varphi(\omega))$$

$$\varphi(\omega) = \varphi(\omega_0) + \varphi'(\omega_0)(\omega - \omega_0) + \frac{1}{2} \varphi''(\omega_0)(\omega - \omega_0)^2 + \frac{1}{6} \varphi'''(\omega_0)(\omega - \omega_0)^3 + \dots$$

$$\tau_g(\omega) = \varphi'(\omega)$$

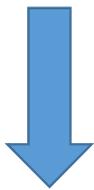
Group delay = relative delay of a spectral component



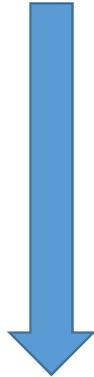
Effects of the spectral Phase

$$\mathcal{E}(\omega) = |\mathcal{E}(\omega)| \exp(i\varphi(\omega))$$

$$\varphi(\omega) = \varphi(\omega_0) + \varphi'(\omega_0)(\omega - \omega_0) + \frac{1}{2} \varphi''(\omega_0)(\omega - \omega_0)^2 + \frac{1}{6} \varphi'''(\omega_0)(\omega - \omega_0)^3 + \dots$$



Constant



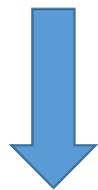
Temporal translation
of the envelope

The first two terms have no impact on the temporal shape

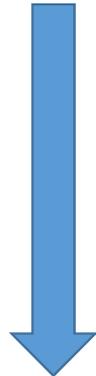
Effects of the spectral Phase

$$\mathcal{E}(\omega) = |\mathcal{E}(\omega)| \exp(i\varphi(\omega))$$

$$\varphi(\omega) = \varphi(\omega_0) + \varphi'(\omega_0)(\omega - \omega_0) + \frac{1}{2} \varphi''(\omega_0)(\omega - \omega_0)^2 + \frac{1}{6} \varphi'''(\omega_0)(\omega - \omega_0)^3 + \dots$$

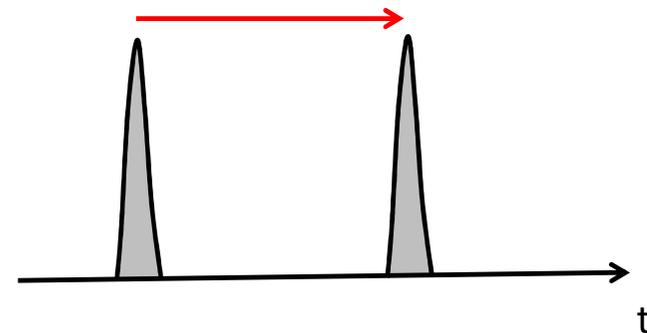


Constant



Temporal translation
of the envelope

$$\tau_g = \varphi'(\omega_0)$$



Effects of the spectral Phase

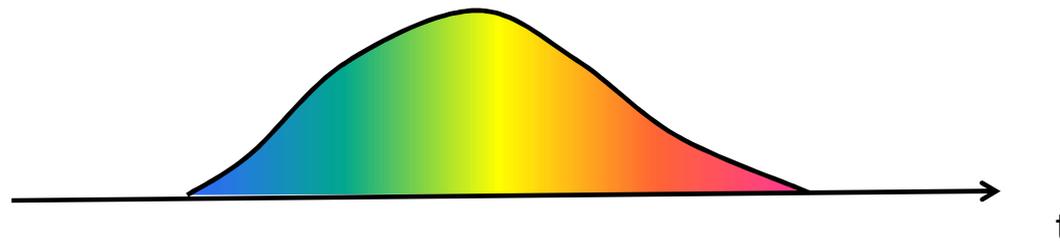
$$\mathcal{E}(\omega) = |\mathcal{E}(\omega)| \exp(i\varphi(\omega))$$

$$\varphi(\omega) = \varphi(\omega_0) + \varphi'(\omega_0)(\omega - \omega_0) + \frac{1}{2} \varphi''(\omega_0)(\omega - \omega_0)^2 + \frac{1}{6} \varphi'''(\omega_0)(\omega - \omega_0)^3 + \dots$$



$$\tau_g(\omega) = \varphi''(\omega_0)(\omega - \omega_0)$$

The group delay varies linearly with the frequency



Parabolic spectral phase

$$\tau_g(\omega) = \varphi''(\omega_0)(\omega - \omega_0)$$

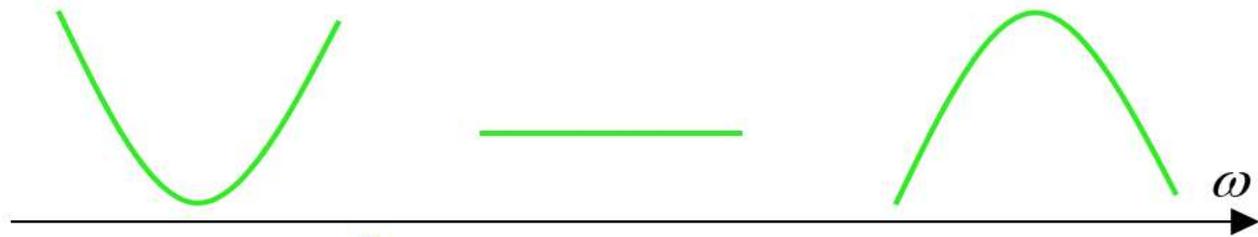
$$\varphi''(\omega_0) > 0$$

$$\varphi''(\omega_0) = 0$$

$$\varphi''(\omega_0) < 0$$

Spectral Phase

$\varphi(\omega)$



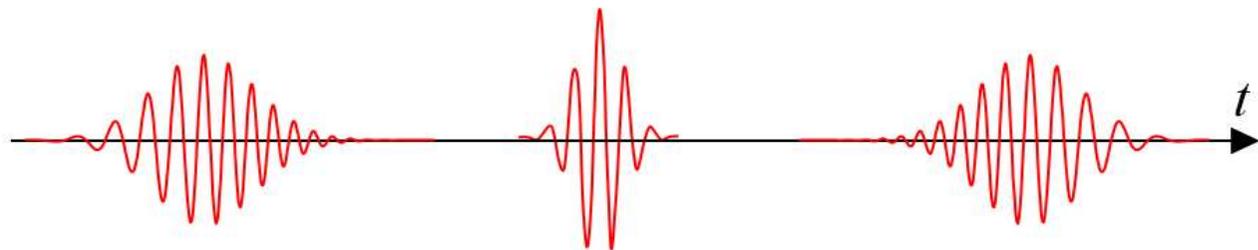
Group delay

$\tau_g(\omega)$



Temporal field

$E(t)$



up-chirped

FT limited

down-chirped

Propagation effects

Spectral phase accumulated by propagation :

$$\varphi(z, \omega) = \varphi(0, \omega) + k(\omega)z \qquad k(\omega) = n(\omega)\omega/c$$

$$\tau_g(z, \omega) = \tau_g(0, \omega) + k'(\omega_0)z + (\omega - \omega_0)k''(\omega_0)z + \dots$$

Propagation effects

Spectral phase accumulated by propagation :

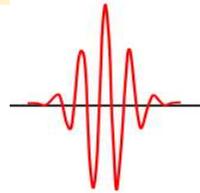
$$\varphi(z, \omega) = \varphi(0, \omega) + k(\omega)z \quad k(\omega) = n(\omega)\omega/c$$

$$\tau_g(z, \omega) = \tau_g(0, \omega) + k'(\omega_0)z + (\omega - \omega_0)k''(\omega_0)z + \dots$$



Constant delay

$$V_g(\omega) = 1/k'(\omega)$$



Group velocity
(velocity of the envelope)

Propagation effects

Spectral phase accumulated by propagation :

$$\varphi(z, \omega) = \varphi(0, \omega) + k(\omega)z$$

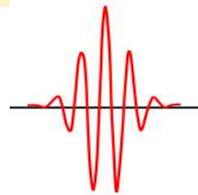
$$k(\omega) = n(\omega)\omega/c$$

$$\tau_g(z, \omega) = \tau_g(0, \omega) + k'(\omega_0)z + (\omega - \omega_0)k''(\omega_0)z + \dots$$

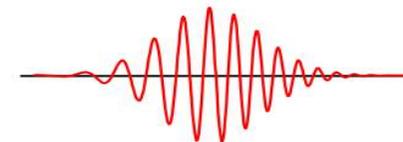
Constant delay

$$V_g(\omega) = 1/k'(\omega)$$

Group velocity
(velocity of the envelope)



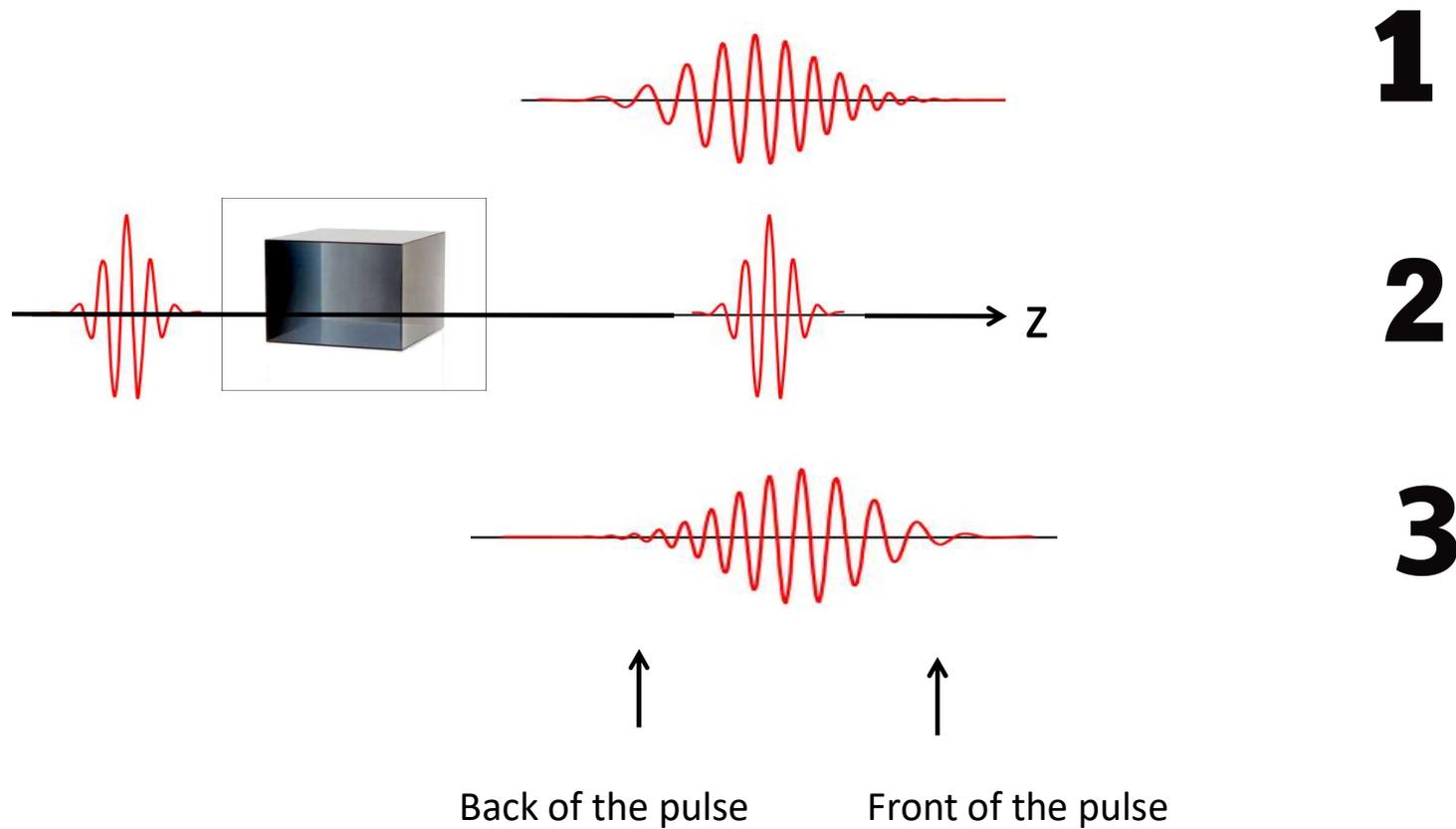
Group Delay Dispersion
(GDD)



The pulse is chirped

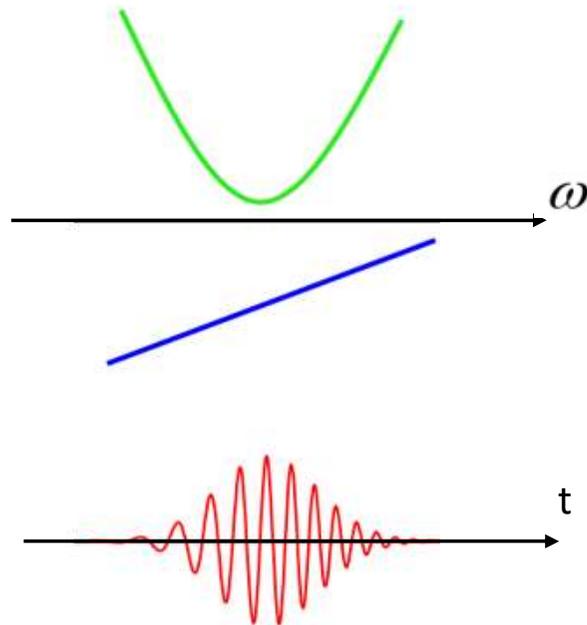
Quizz

What is the output pulse after propagation in a material with $k'' > 0$?



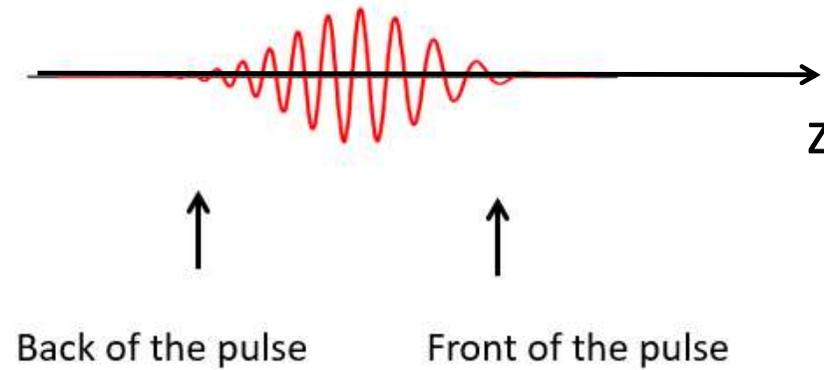
Quizz

$$\varphi''(\omega_0) > 0$$



up-chirped

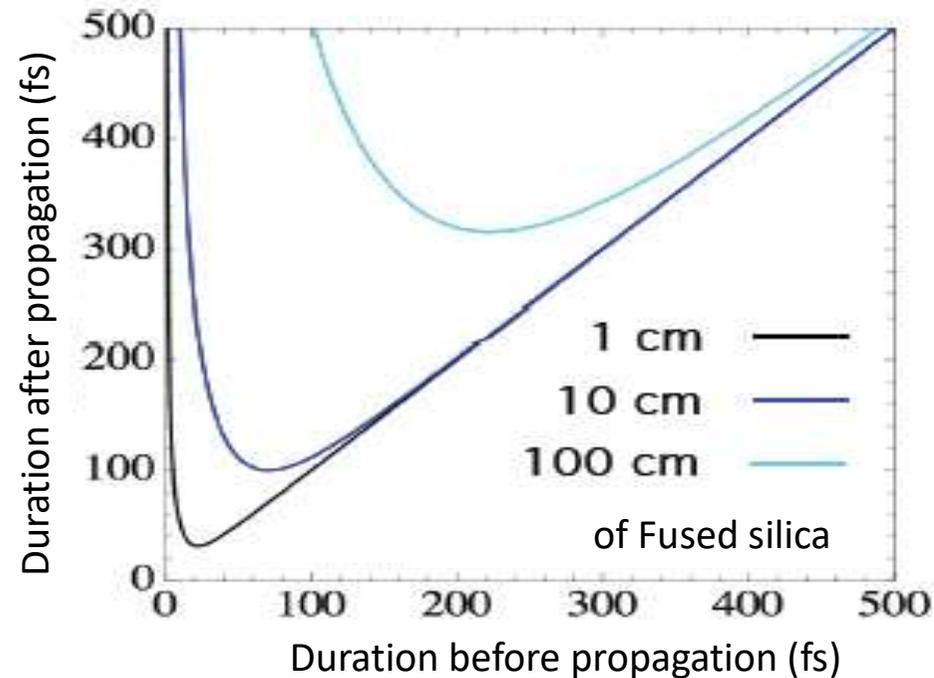
The high frequency components present a higher group delay, they are at the back of the pulse



3

Duration after propagation in a dispersive material

Materials transparent in the visible : $k'' > 0$



Dispersive effects higher for shorter pulses

$$\tau_g(z, \omega) = \tau_g(0, \omega) + k'(\omega_0)z + (\omega - \omega_0)k''(\omega_0)z + \dots$$

Summary 1

$$\varepsilon(\omega) = |\varepsilon(\omega)| \exp(i\varphi(\omega))$$

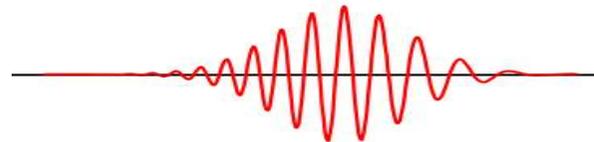
✓ Short Pulse = broad spectrum

$$\Delta t \Delta \omega \geq \frac{1}{2}$$

✓ The spectral phase governs the temporal shape

✓ Non linear spectral phase = group velocity dispersion

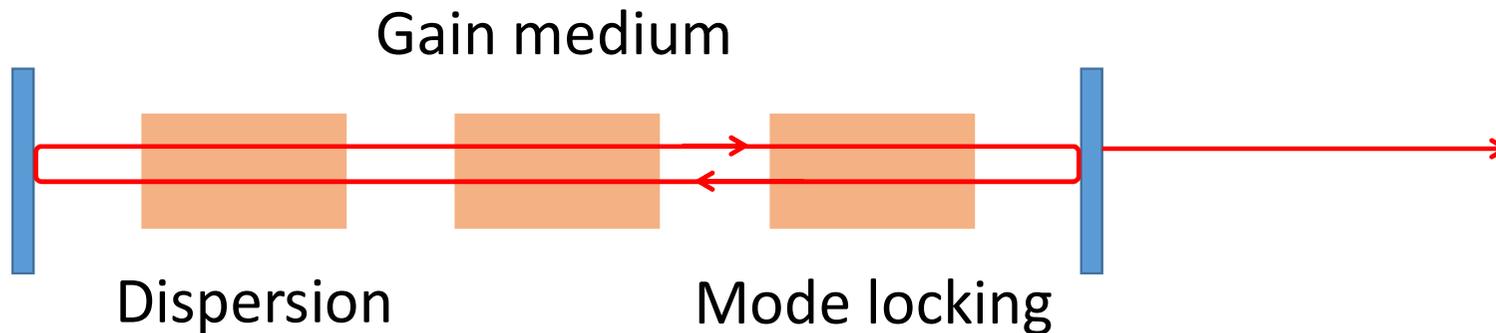
✓ Propagation in transparent material = up chirped pulse



Introduction

1. Description of ultrashort light pulses
2. Generation of femtosecond laser pulses via mode locking
3. Femtosecond oscillator technology

Fundamental of mode locking



✓ Compensation of the dispersion

- Prisms
- Gratings
- Chirped mirrors

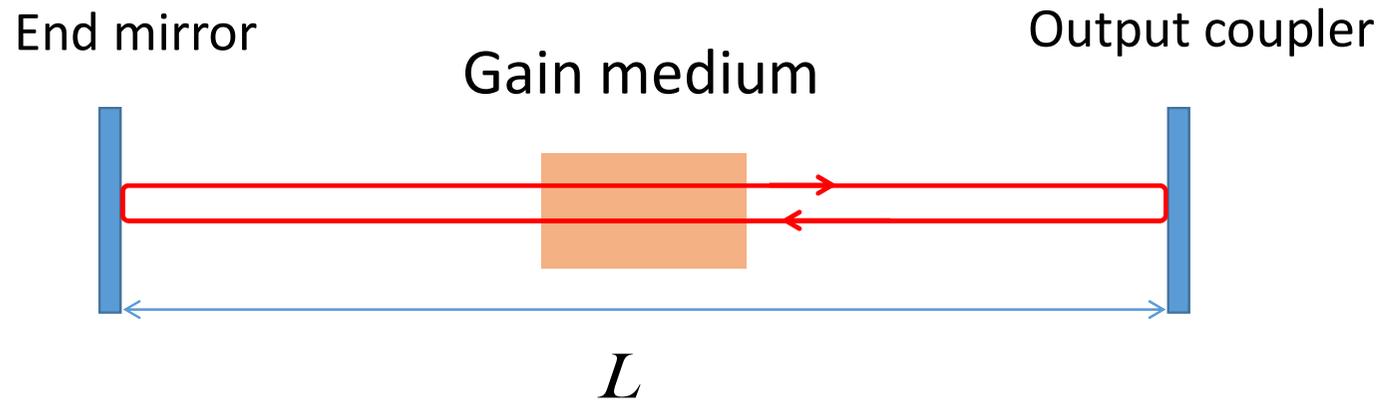
✓ Gain medium

- Gain
- Wavelength
- Pulse duration
- Pumping

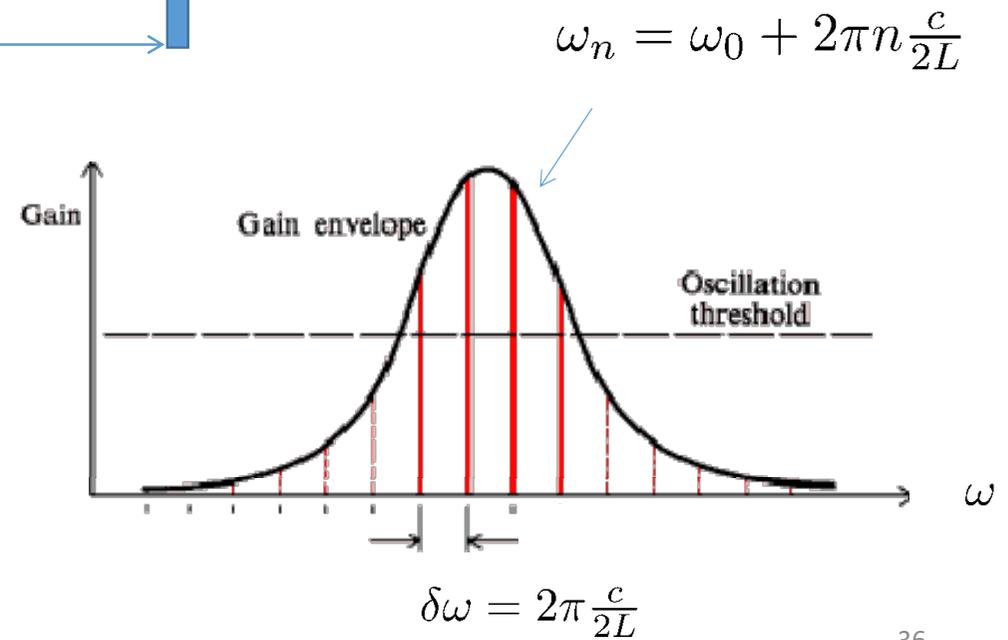
✓ Non linear effect for mode locking

- AOM
- Kerr-lens
- Saturable absorber

Gain medium

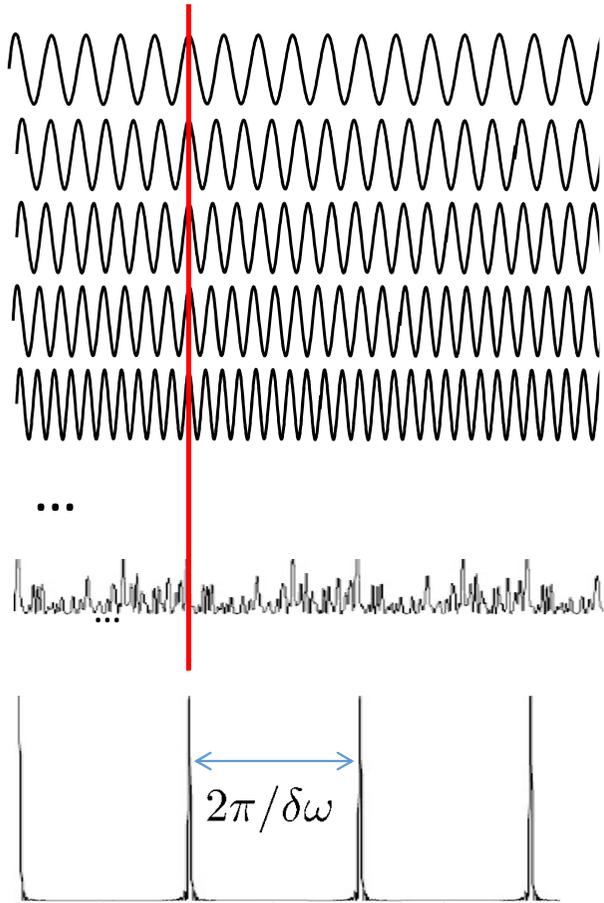


Longitudinal modes in the frequency domain



Longitudinal modes

in time domain



$$\omega_n \quad \phi_n(t)$$

$$\omega_{n+1} \quad \phi_{n+1}(t)$$

$$\omega_{n+2} \quad \phi_{n+2}(t)$$

$$\omega_{n+3} \quad \phi_{n+3}(t)$$

$$\omega_{n+4} \quad \phi_{n+4}(t)$$

Example :

$$\lambda = 800nm$$

$$\Delta\lambda = 80nm$$

N modes >100 000

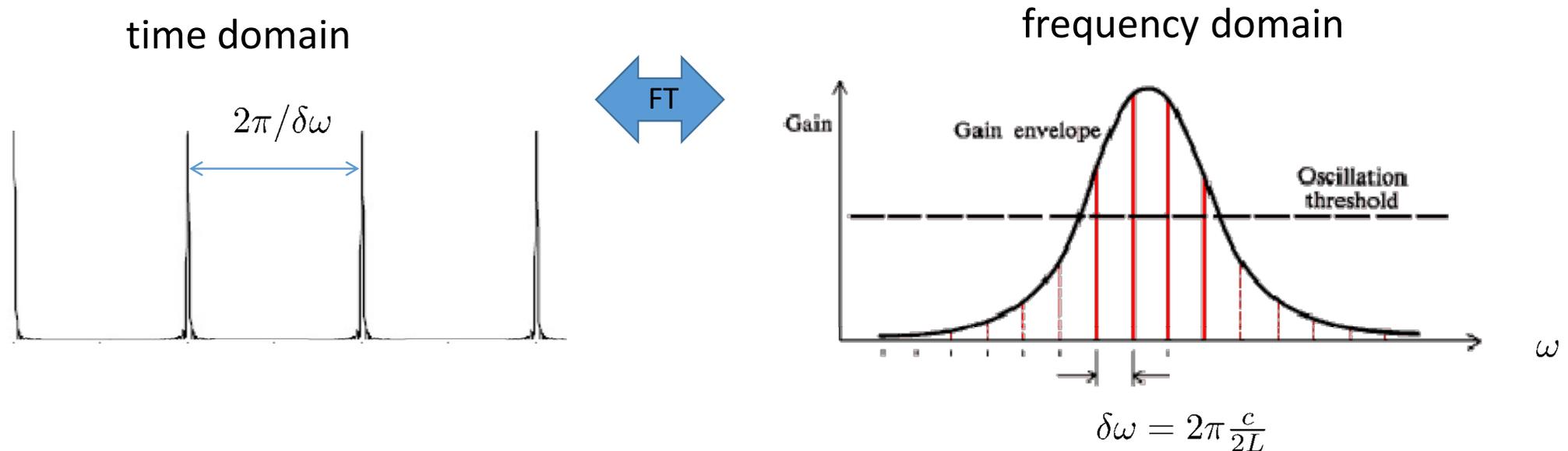
Random phase modes

In-phase modes : $\phi_n(t) = 0$

$$\delta\omega = 2\pi \frac{c}{2L}$$

$$I(t) = I_0 \left[\frac{\sin(N\delta\omega t/2)}{\sin(\delta\omega t/2)} \right]^2$$

Mode locking



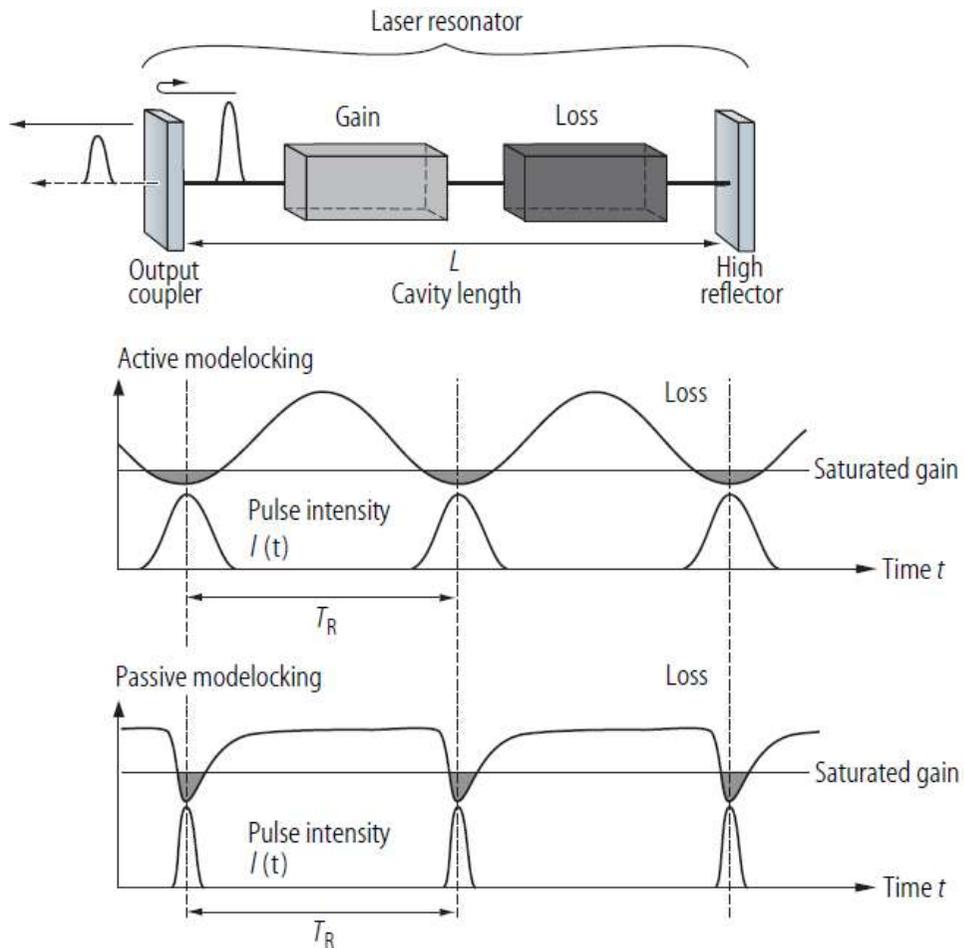
Mode locking = phases locked $\phi_n = n\alpha$

Train pulses separated by the round trip time

Spectral width increases with N

Duration decreases with N $T = 2\pi/\delta\omega = 2L/c$

Mode locking



Idea :to favor pulsed regime over continuous one

➔ Loss modulation

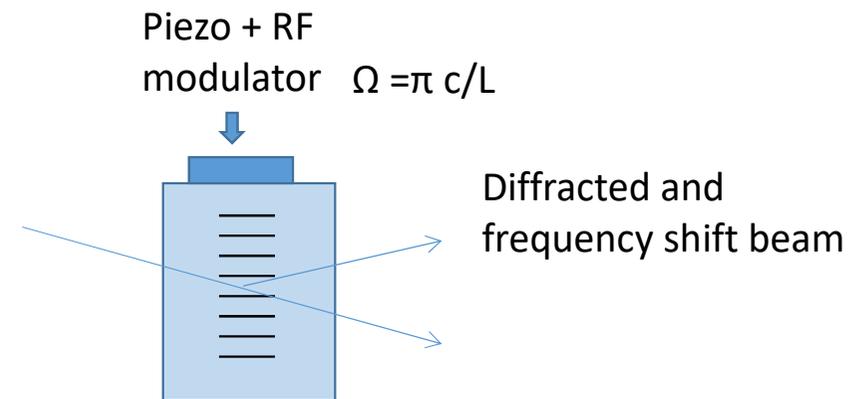
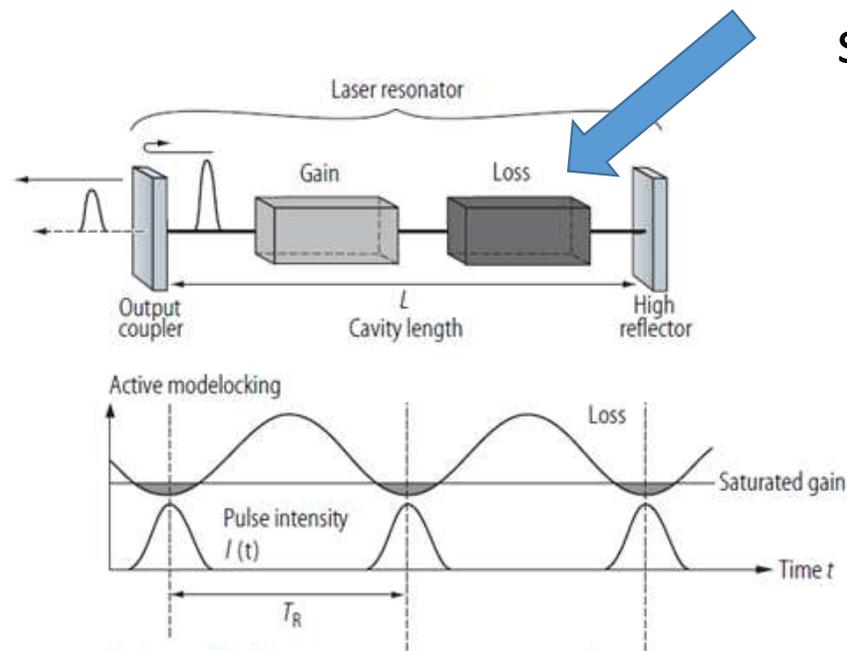
- Active modelocking
 - Acousto-optic modulator
 - Electro-optic modulator
- Passive modelocking
 - KLM
 - SESAM

Figure from book chapter *Ultrafast solid-state lasers*, Ursula Keller

Fig. 2.1.3. Schematic laser cavity setup for active and passive mode-locking.

Active modelocking

Acousto-optic (or electro-optic) modulator synchronized with the resonator round trip



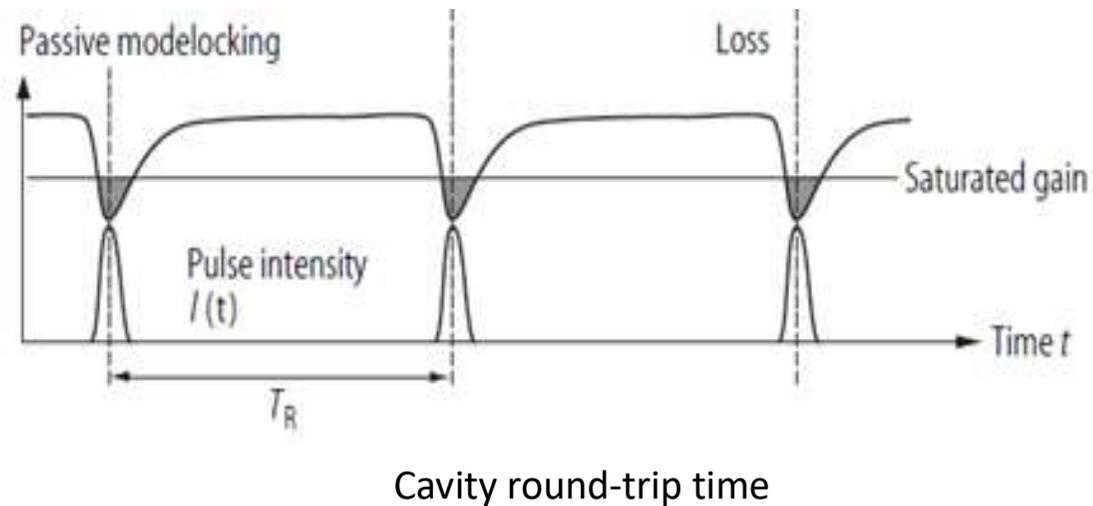
Generation of a grating that turns ON and OFF at a frequency $2\Omega = c/2L$

Passive modelocking

Self amplitude modulation of the light by **fast** loss saturation

Shorter pulse

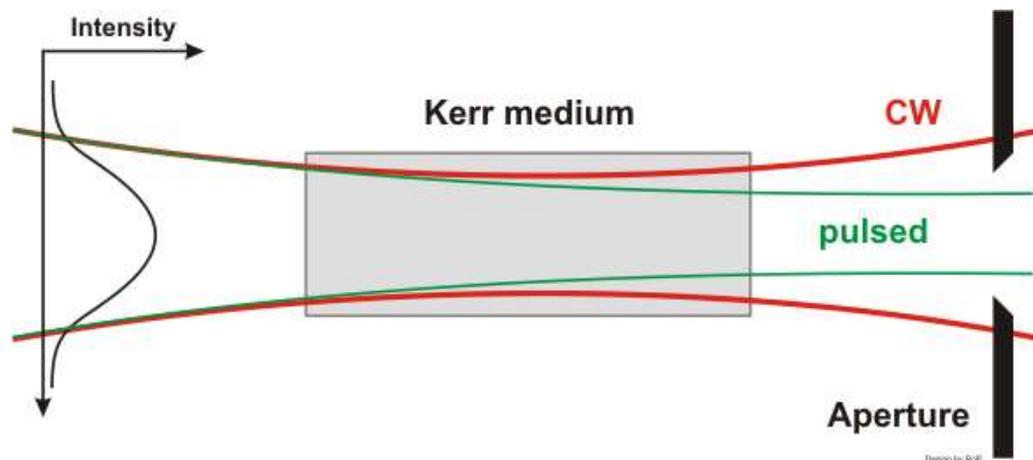
Starting with noise fluctuations



- Kerr Lens
- Saturable absorber

Kerr lens modelocking

Kerr effect: Nonlinear change in refractive index $n(r) = n_0 + n_2 I(r)$
Fast (few fs) and broadband



KLM = Kerr Lens Modelocking

Self focusing + hard or
« soft » aperture

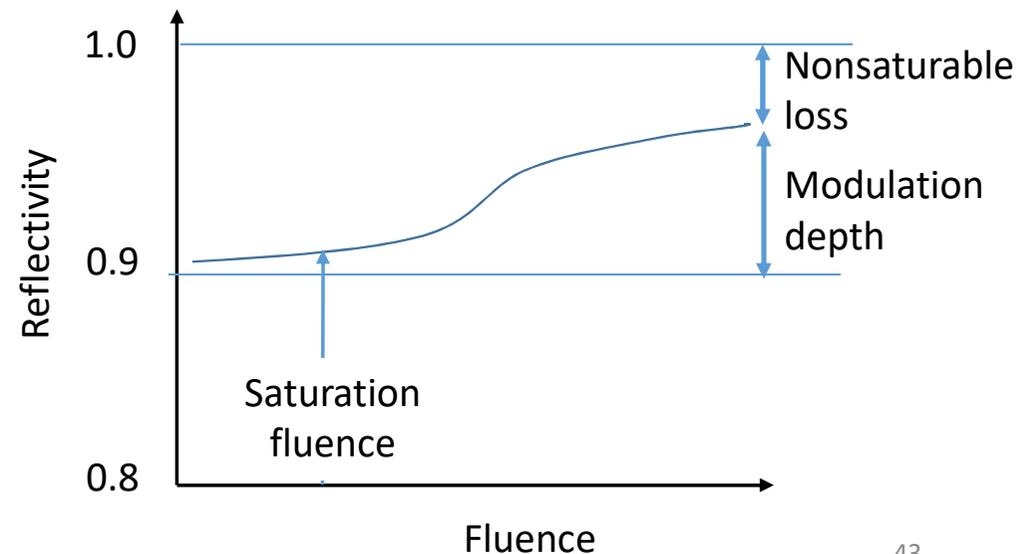
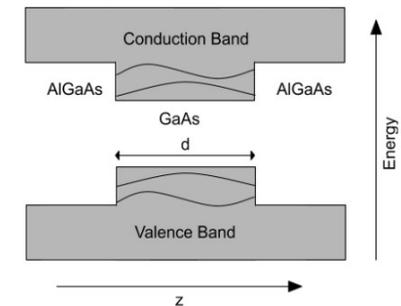
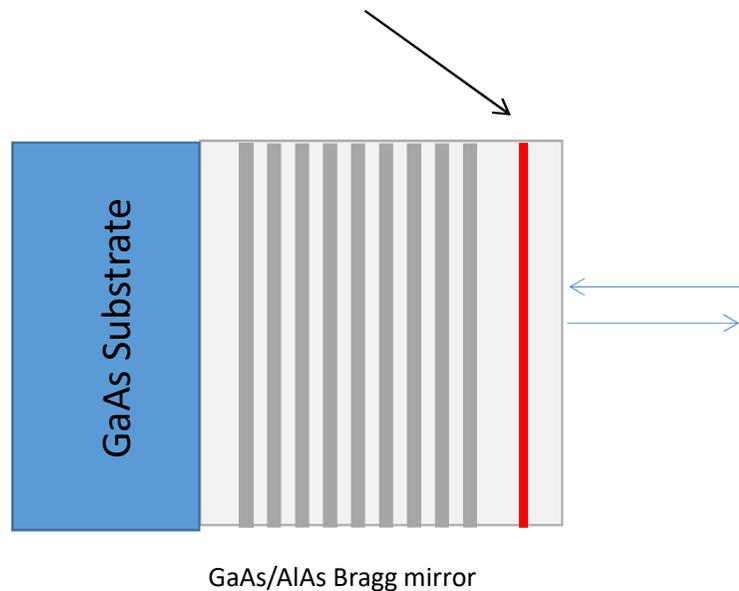
Not self starting : vibrating
mirror or saturable absorber

Saturable absorber

Saturable absorber : component with losses reduced by high intensities

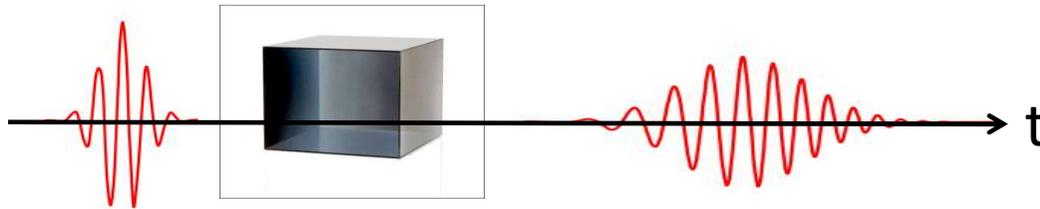
SESAM : Semiconductor Saturable Absorber Mirror

InGaAs quantum well absorber on a Bragg mirror



Dispersion management

How to compensate for the dispersion in the cavity?

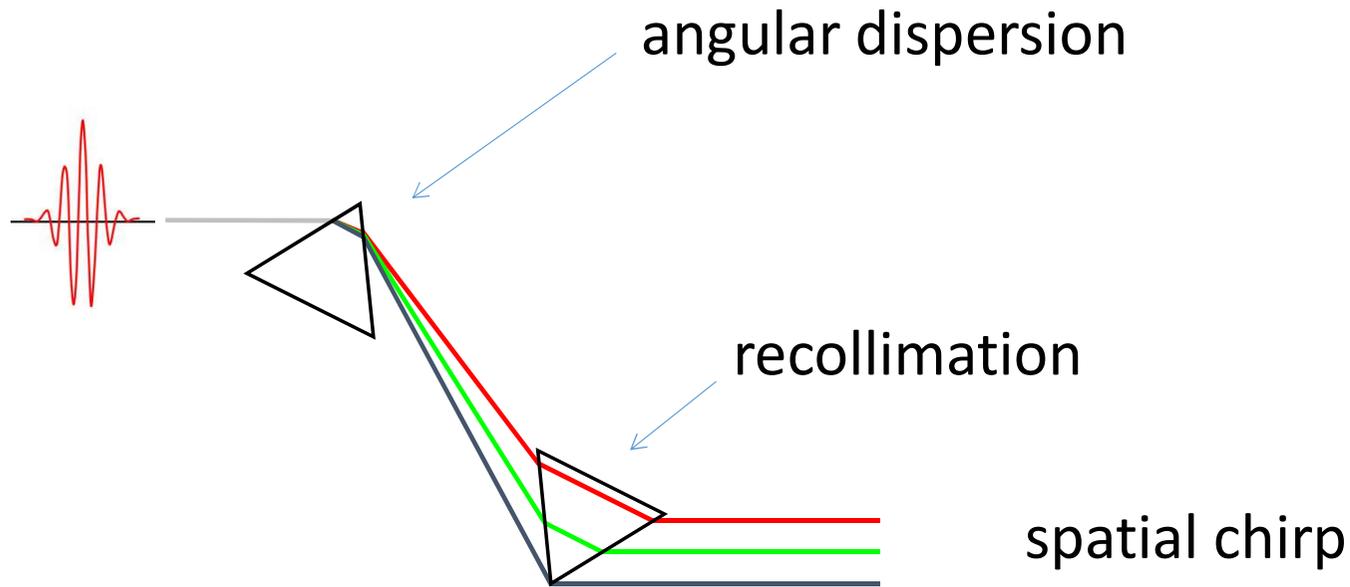


DVG > 0 in the visible

- ✓ Prisms
- ✓ Gratings
- ✓ Chirped mirrors

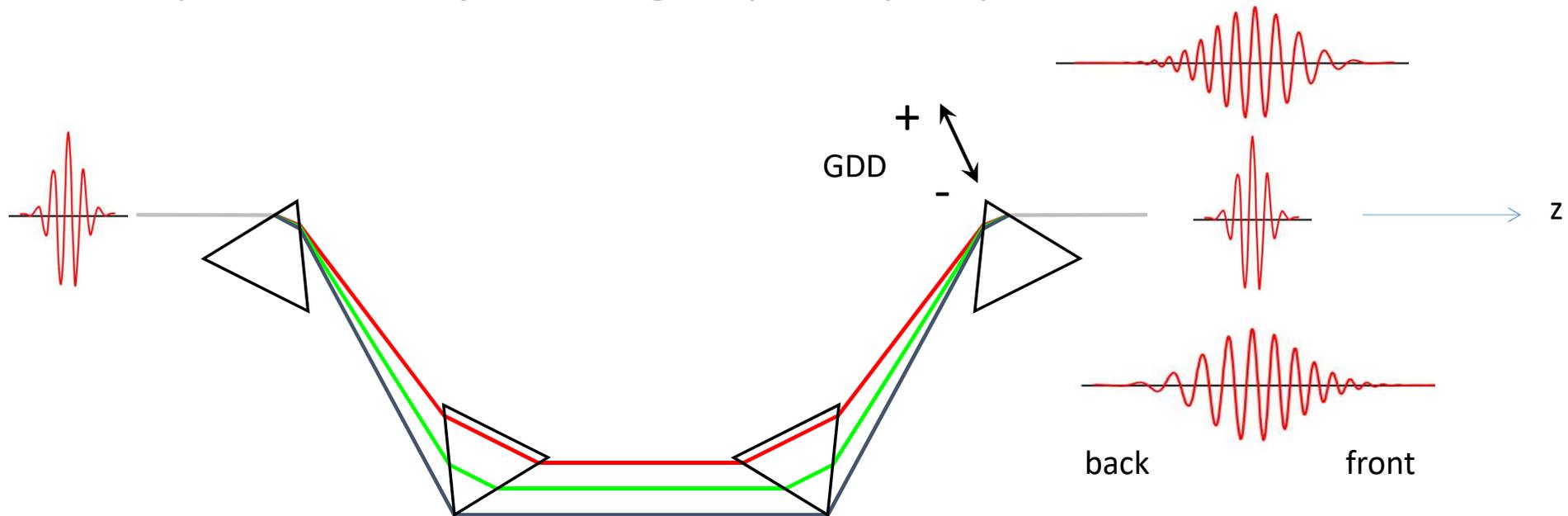
Dispersion management with prisms

Prism sequence for adjustable group delay dispersion.



Dispersion management with prisms

Prism sequence for adjustable group delay dispersion.



GDD

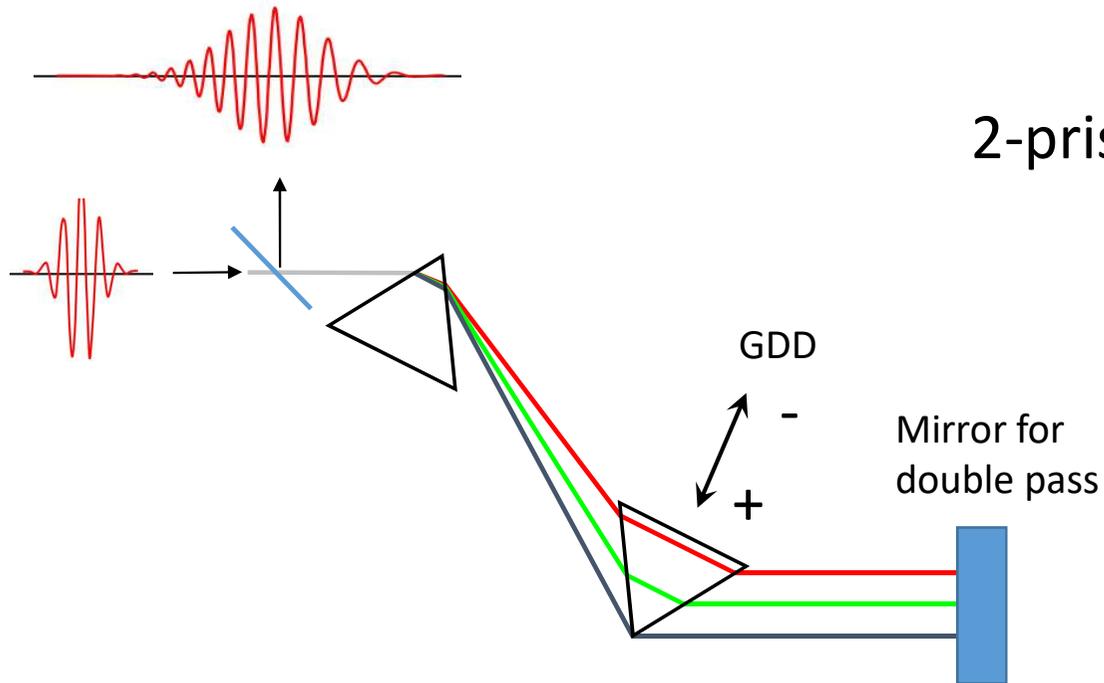
$$\frac{d^2\phi_{fourprisms}}{d\omega^2} \approx \frac{d^2\phi_m}{d\omega^2} + \frac{d^2\phi_p}{d\omega^2} = \frac{\lambda^3 L}{2\pi c^2} \frac{d^2 n}{d\lambda^2} - \frac{4l_p \lambda^3}{\pi c^2} \left(\frac{dn}{d\lambda} \right)^2$$

l_p distance between prisms
 L mean glass pass

TOD

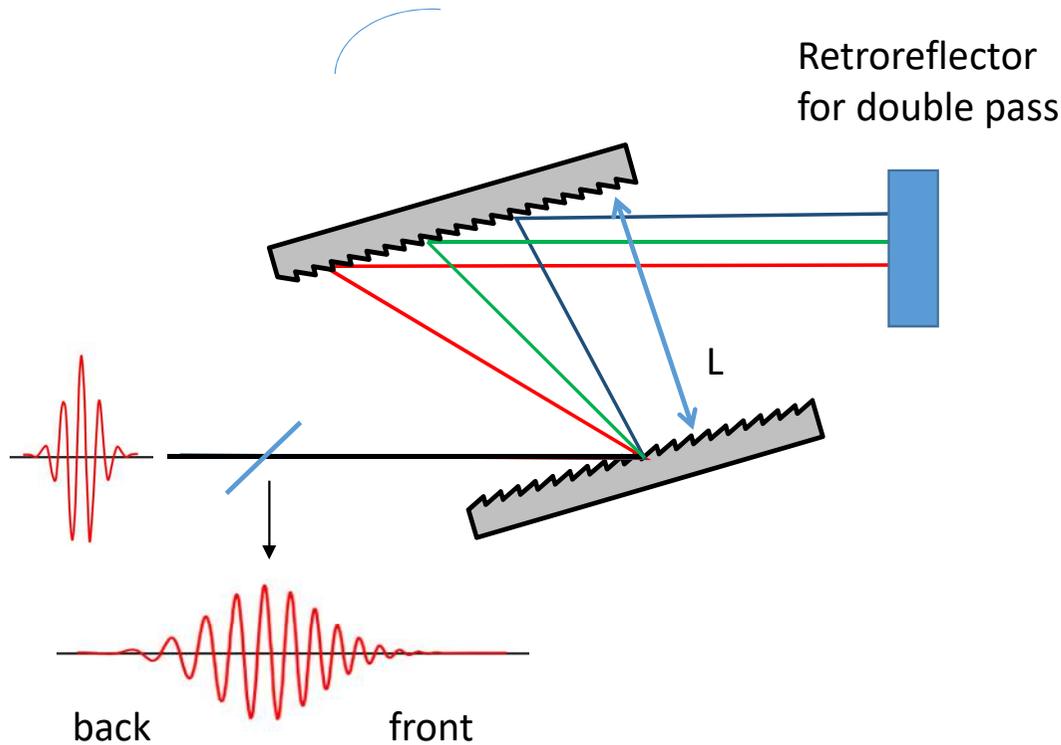
$$\frac{d^3\phi_{fourprisms}}{d\omega^3} \approx \frac{d^3\phi_m}{d\omega^3} + \frac{d^3\phi_p}{d\omega^3} = \frac{-\lambda^4 L}{4\pi^2 c^3} \left(3 \frac{d^2 n}{d\lambda^2} + \lambda \frac{d^3 n}{d\lambda^3} \right) + \frac{6l_p \lambda^4}{\pi^2 c^3} \frac{dn}{d\lambda} \left(\frac{dn}{d\lambda} + \lambda \frac{d^2 n}{d\lambda^2} \right)$$

Dispersion management with prisms



2-prism sequence in double pass

Dispersion management with gratings



p diffraction order

d grating pitch

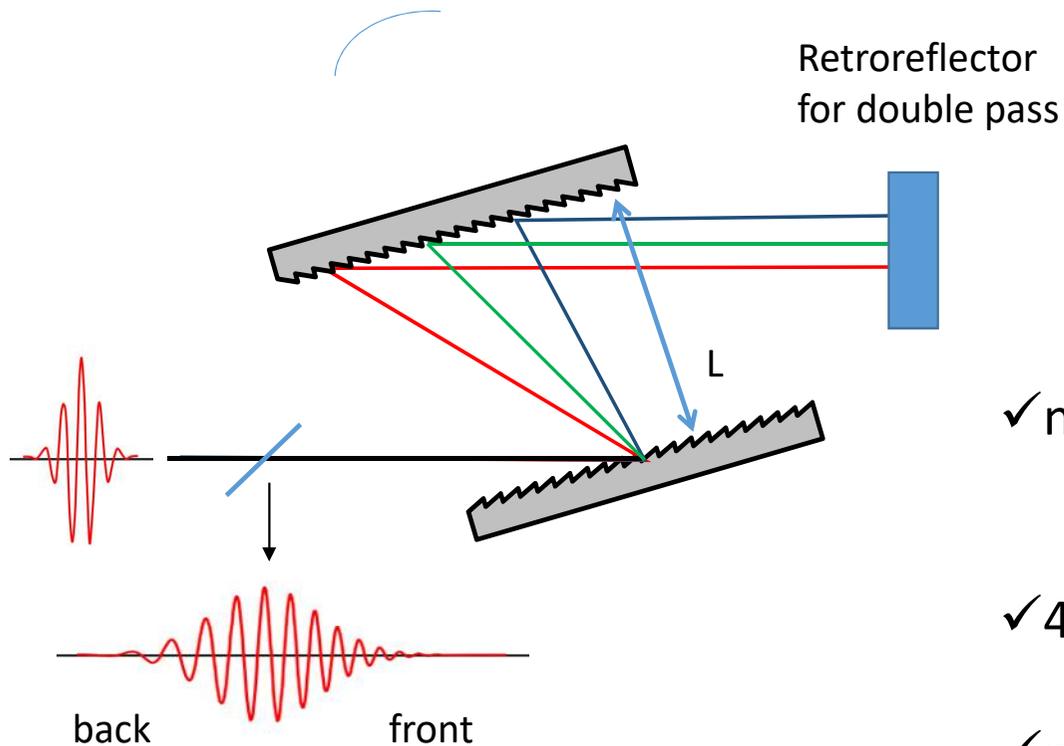
i angle of incidence

θ angle of the reflected wavelength

$$\frac{d^2\varphi}{d\omega^2} = \frac{-8\pi^2 cL}{\omega^3 d^2 \cos^3 \theta} < 0 \quad (p = 1)$$

$$\frac{d^3\varphi}{d\omega^3} = \frac{12\pi^2 cL}{\omega^4 d^2} \frac{1 + \frac{2\pi c}{\omega d} \sin i - \sin^2 i}{\cos^5 \theta} > 0$$

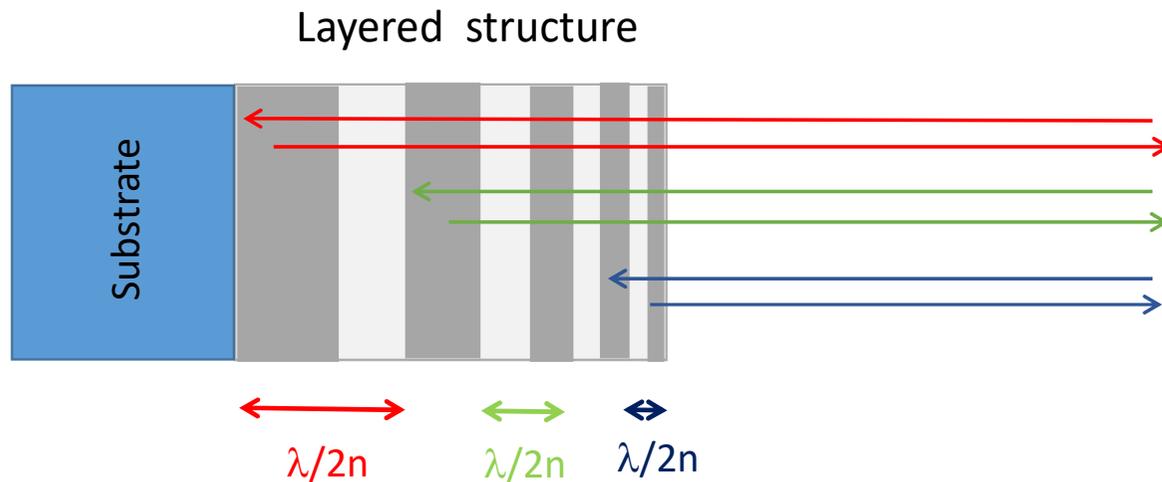
Dispersion management with gratings



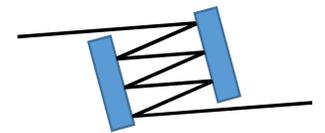
- ✓ negative group delay
 - ✓ Distance between gratings
 - ✓ Gratings pitch
- ✓ 4 gratings or 2 gratings in double pass
- ✓ much more dispersive than prisms but introduces higher losses

Dispersion management with chirped mirror

Bragg mirror with variable layer thickness values



- ✓ Compact
- ✓ High reflectivity
- ✓ Can compensate for higher orders
- ✓ Fixed GDD -> multiple reflections



The repetition rate of a femtosecond oscillator is related to:

- The acousto-optic modulator
- The length of the cavity
- the pulse width

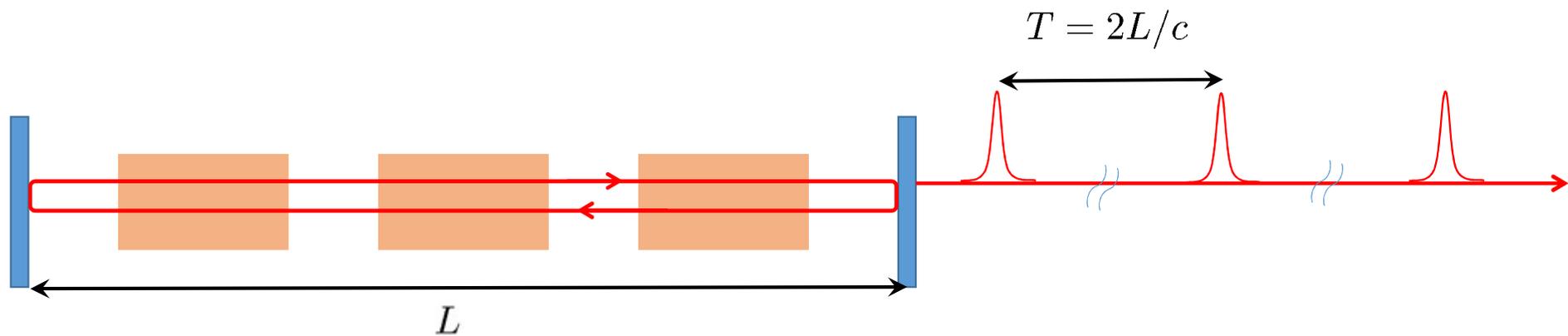
1

2

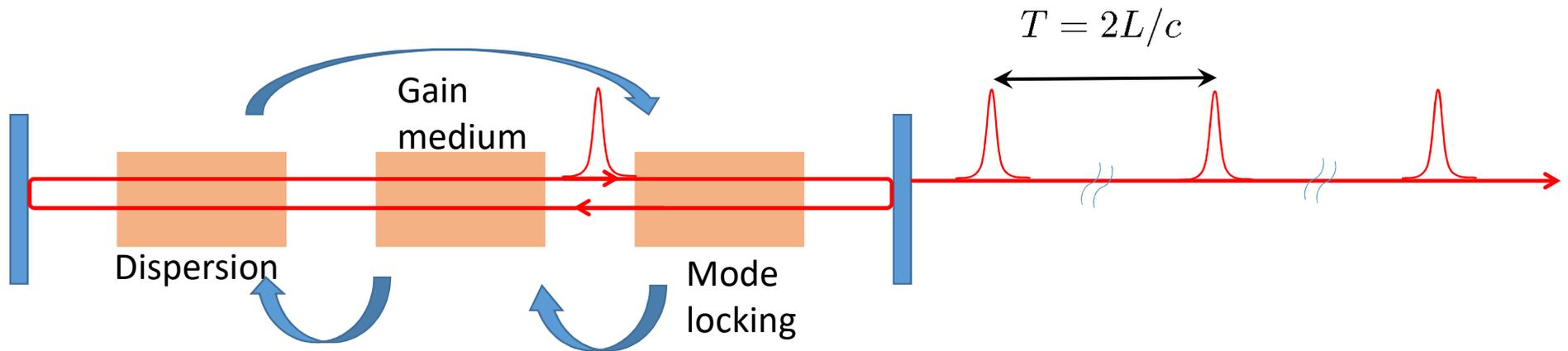
3

The repetition rate of a femtosecond oscillator is related to:

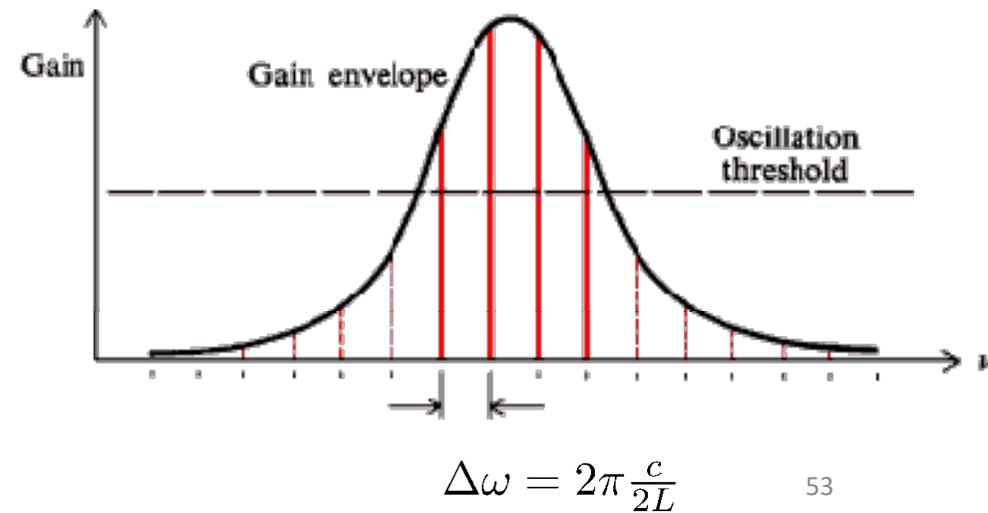
- The length of the cavity **2**



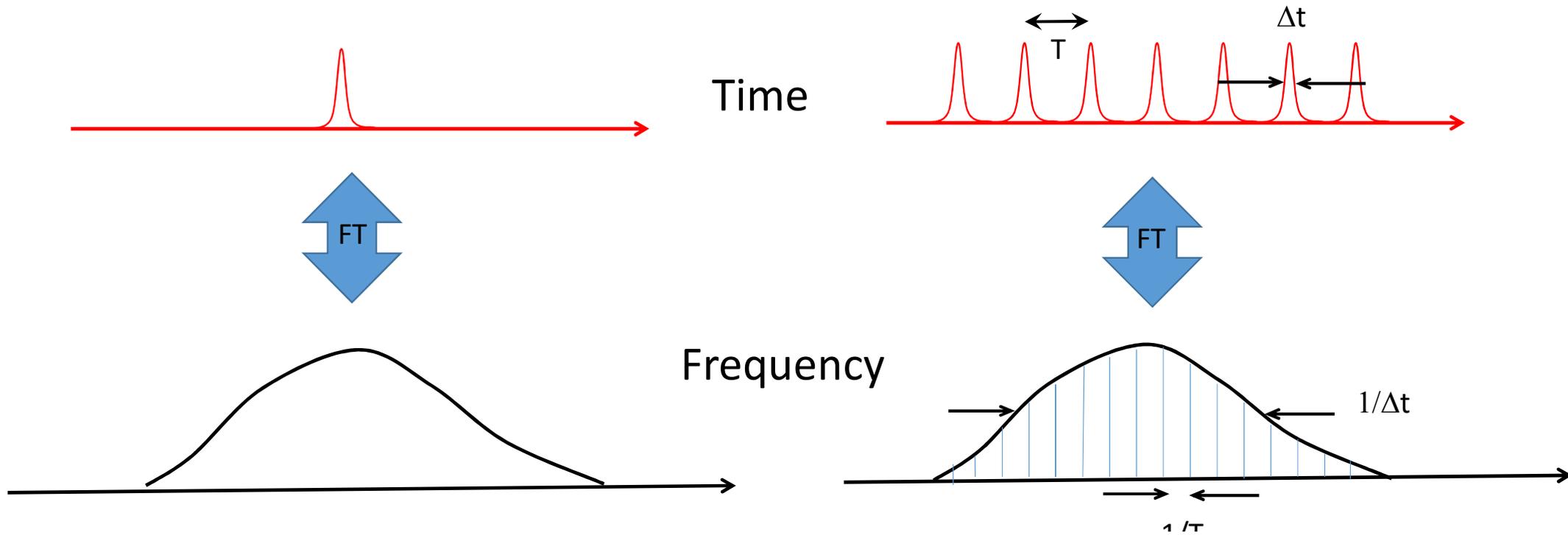
Summary 2



Mode locking is a balance between dispersion and NL effects. It allows **exact** adjustment of the phase of the modes.



Frequency comb



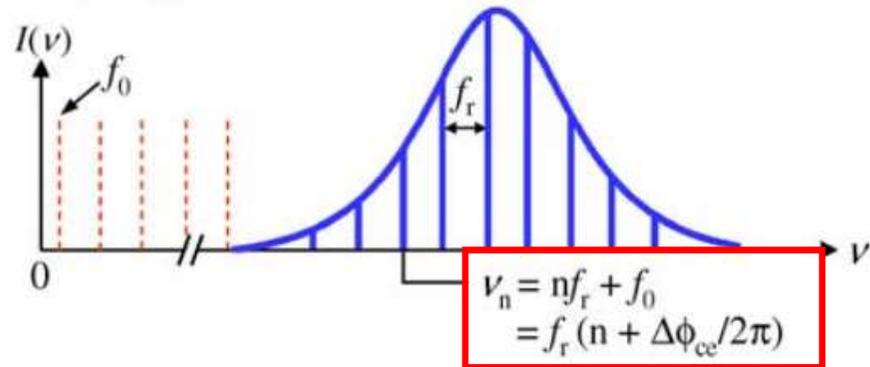
Discrete and perfectly equally spaced frequency lines



➤ frequency etalon

The carrier envelope phase

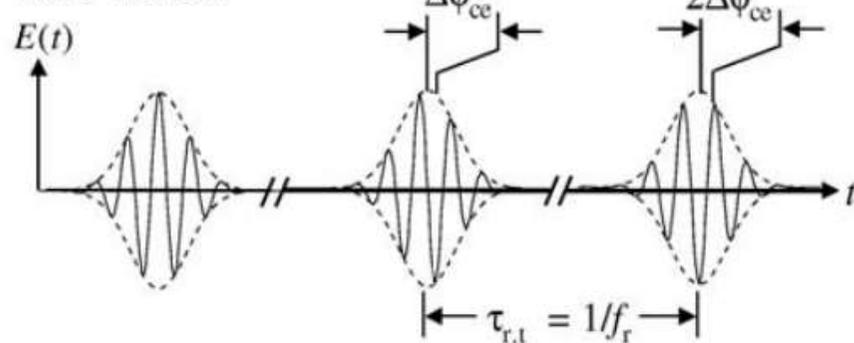
Frequency domain



f_r Repetition rate 100MHz-GHz

f_0 Carrier Enveloppe Offset (CEO)

Time domain



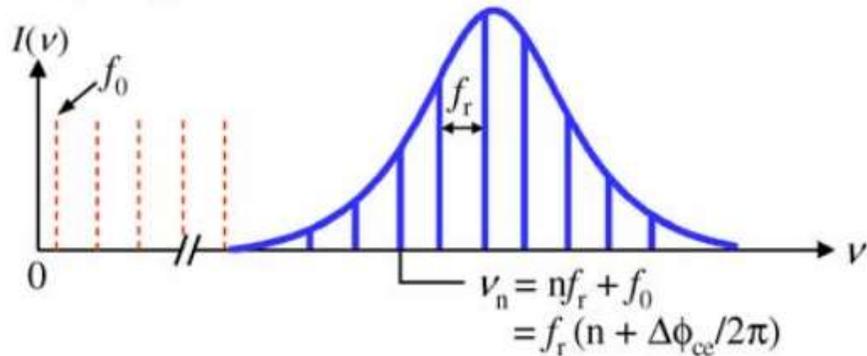
For very short pulse, difference between phase and group velocities matters

$$f_0 = \frac{\Delta\phi_{CE}}{2\pi} f_r$$

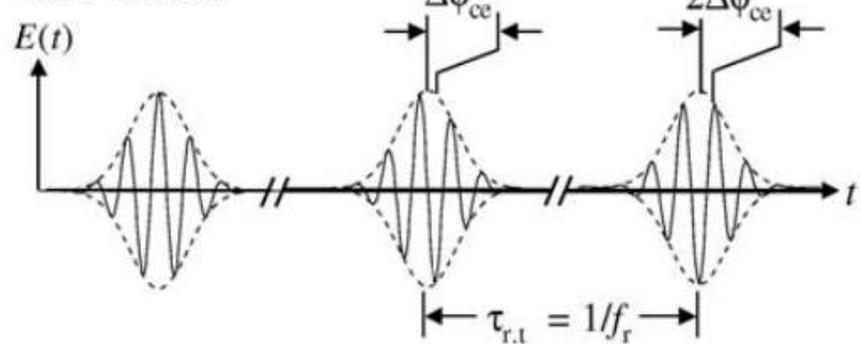
$$\Delta\phi_{CE} = L\omega_0 \left(\frac{1}{v_g} - \frac{1}{v_\varphi} \right)$$

Frequency comb for optical clock

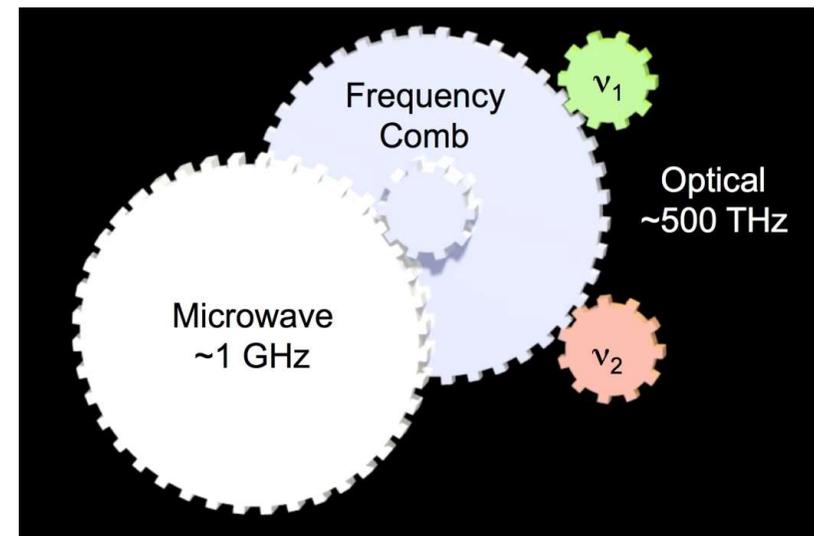
Frequency domain



Time domain



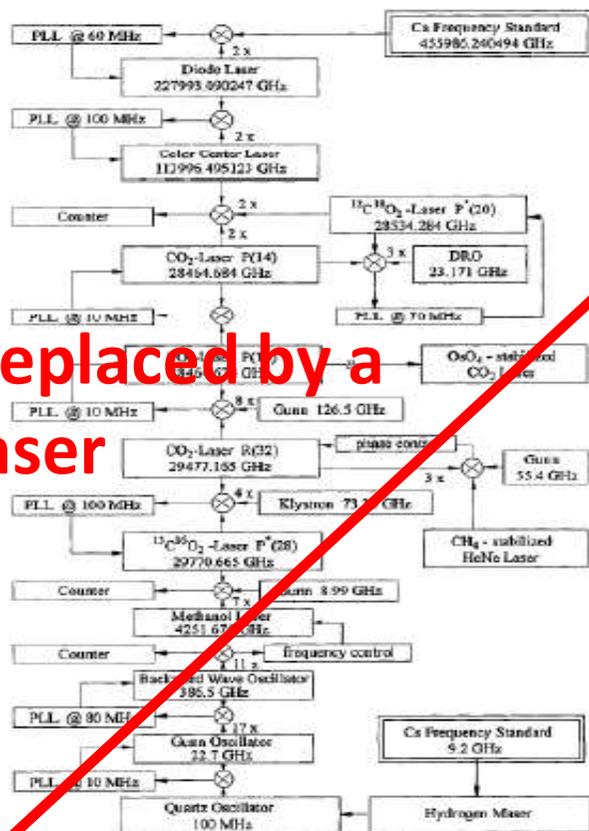
f_r and f_0 are
Microwave frequencies (100MHz-GHz)
linked to **optical frequencies (THz)**



<https://www.nist.gov/programs-projects/femtosecond-laser-frequency-combs-optical-clocks>

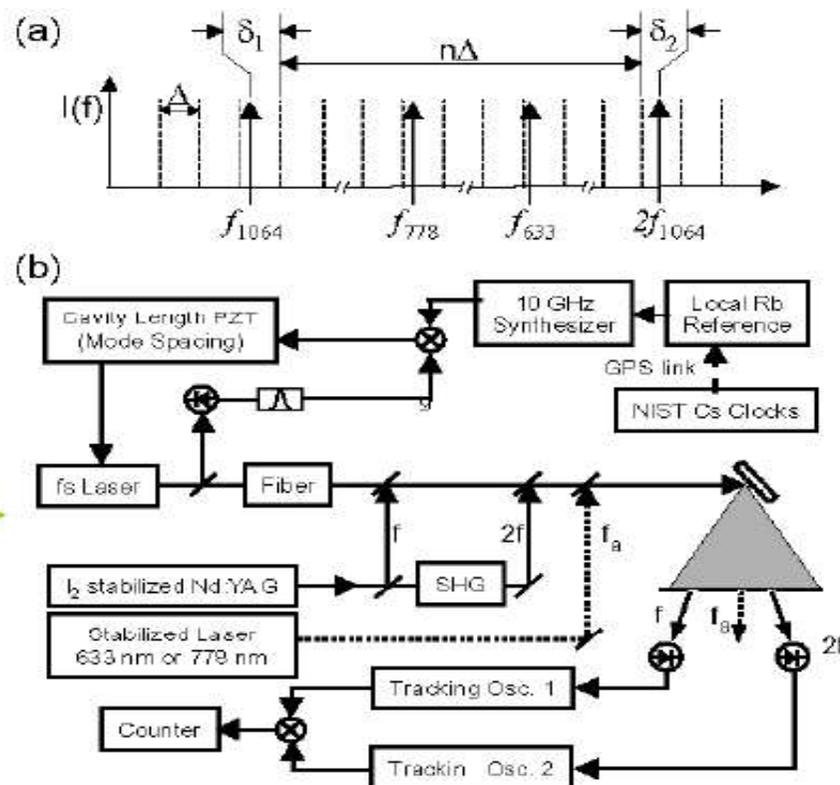
➔ Optical clock

A revolution in the measure of time/frequency



Replaced by a laser

Phys. Rev. Lett. 76, 18 (1996)

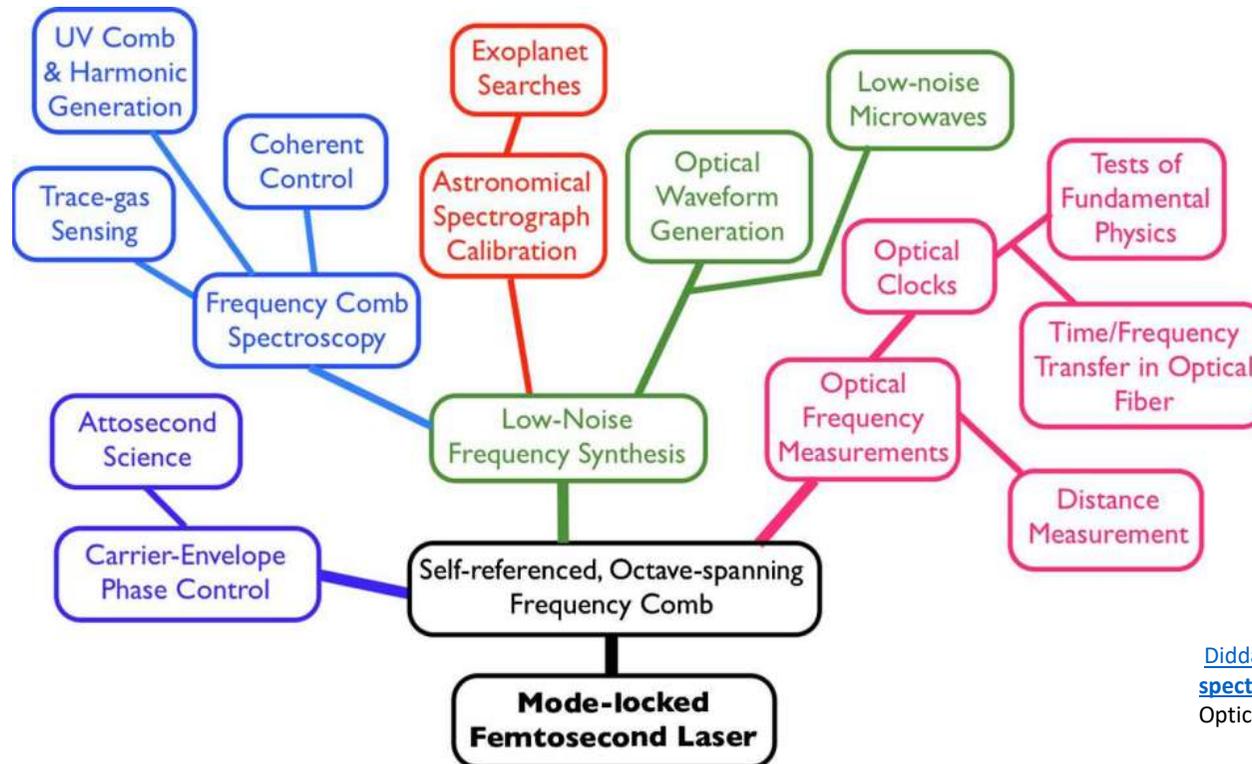


Phys. Rev. Lett. 84, 5102 (2000)

Précision : 2×10^{-13} (50 Hz pour une fréquence de 282 THz)

Frequency comb evolutionary tree

fs oscillator = « comb generator »



Diddams SA. 2008. [Direct frequency comb spectroscopy](#). *Advances in Atomic, Molecular, and Optical Physics*. 55:1–6

Introduction

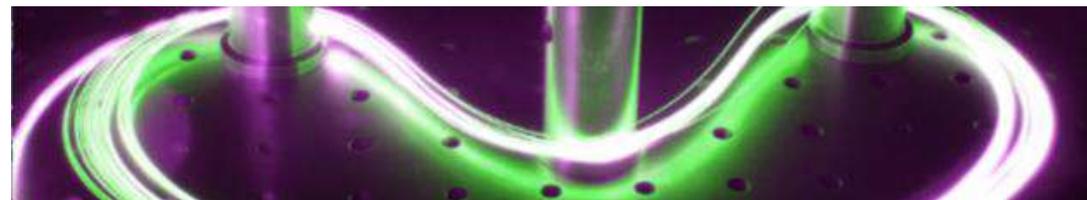
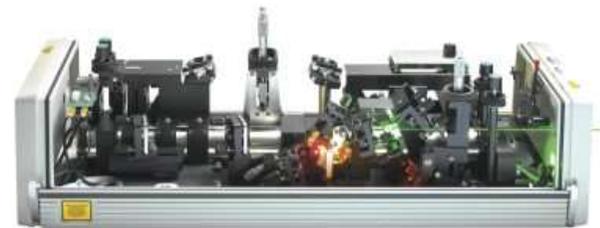
1. Description of ultrashort light pulses
2. Generation of femtosecond laser pulses via mode locking
3. Femtosecond oscillator technology

Femtosecond oscillator technology

✓ Ti:Sapphire oscillators

✓ Yb:bulk oscillators

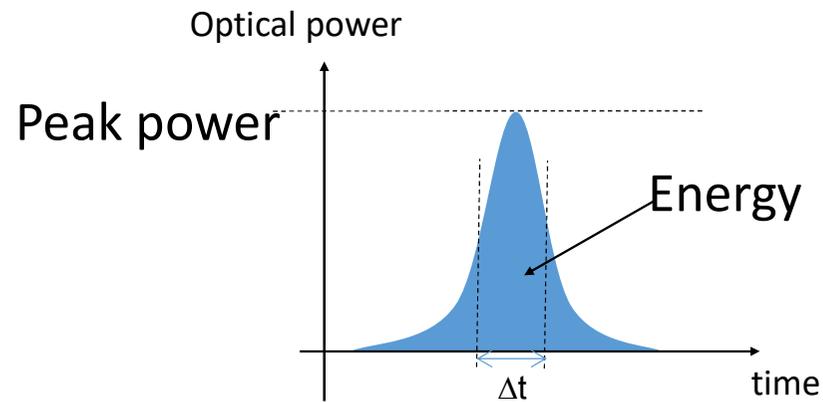
✓ Fiber-based oscillators



© LCF

Laser specifications

Energy	Energy per pulse	Joule
Average power	Energy per unit time	Watt
Peak power	Maximum power	Watt
Intensity (irradiance)	Peak power per unit area	Watt/cm ²

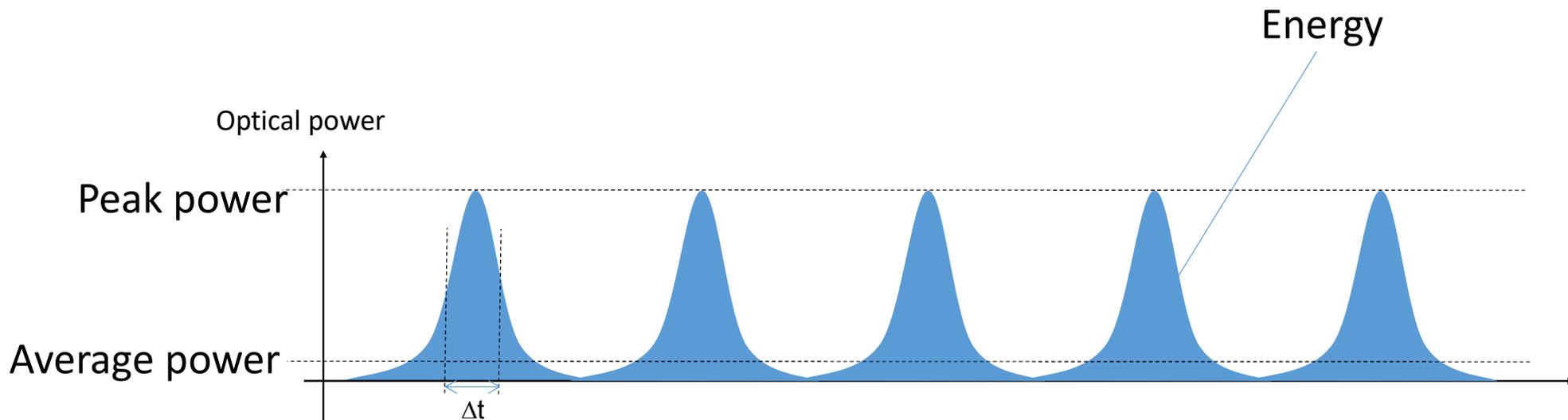


Quizz

Pulse width	10 fs
Energy	10 nJ
Repetition rate	100 MHz
Average power?	
Peak power?	

Quizz

Pulse width	10 fs
Energy	10 nJ
Repetition rate	100 MHz
Average power?	1 W = 10 nJ x 100 MHz
Peak power?	1 MW = 10 nJ / 10fs



Ti:Sapphire oscillator

Sapphire crystals doped with ions Ti^{3+}



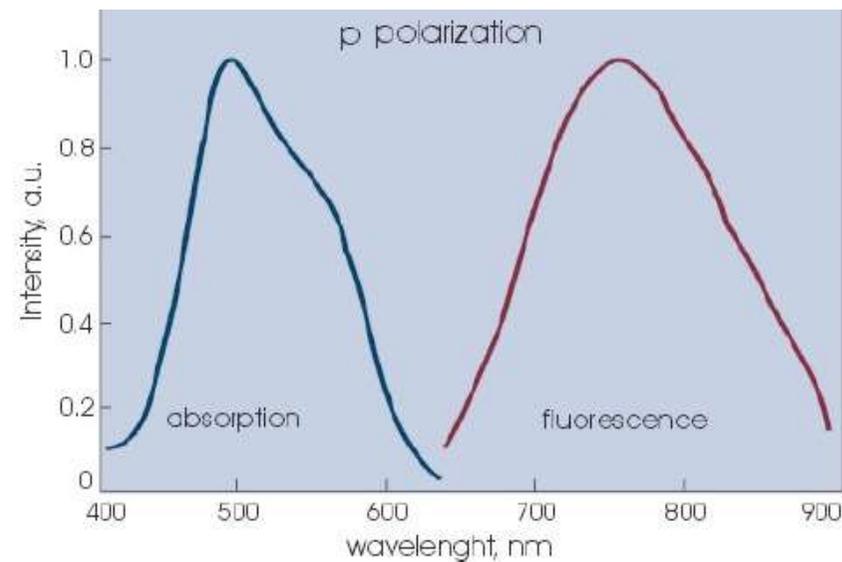
Good thermal conductivity

Very broad gain bandwidth from 650 nm to 1100 nm

Large emission cross section ($41 \cdot 10^{-20} \text{ m}^2$ @ 780 nm)

➔ Extreme tunability and short duration

Ti:Sa emission and absorption spectra



Ti:Sapphire oscillator

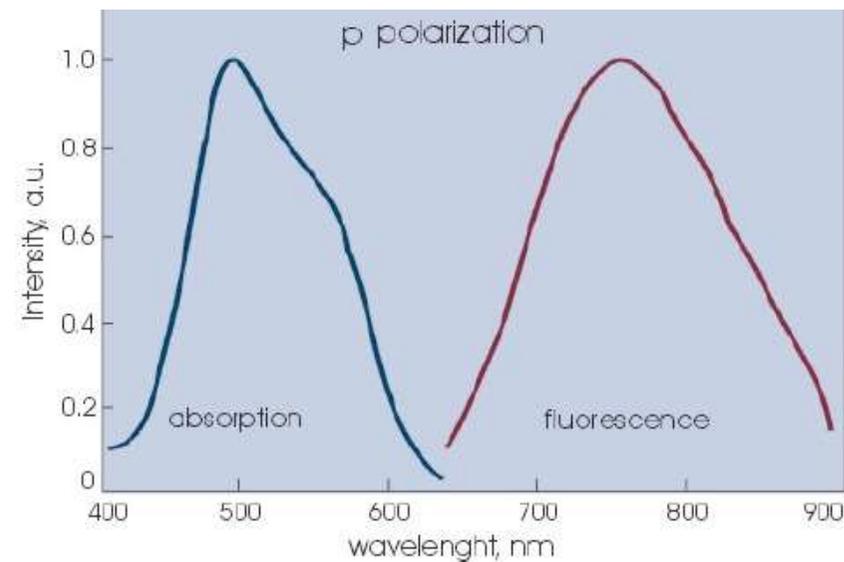
Large quantum defect (energy difference between pump and laser photons)

Pump : green CW laser (DPSS :frequency doubled diode-pumped laser)

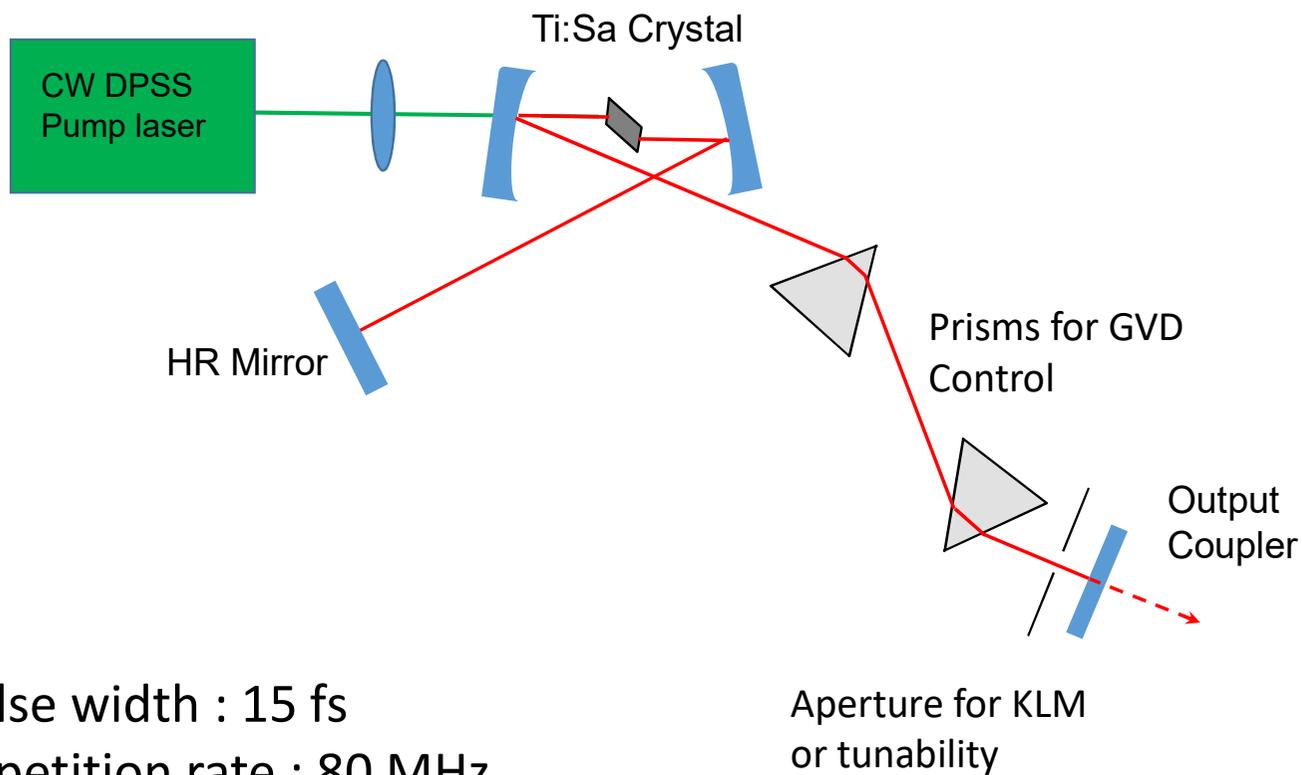


➡ Energetically inefficient, complex and expensive

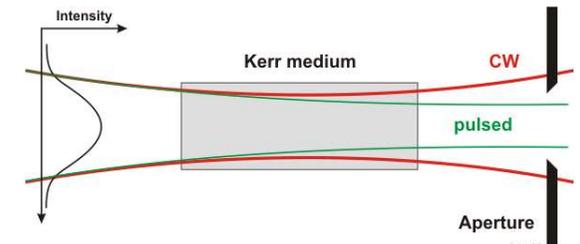
Ti:Sa emission and absorption spectra



Ti :Sapphire cavity



Pulse width : 15 fs
Repetition rate : 80 MHz
Energy : 10 nJ

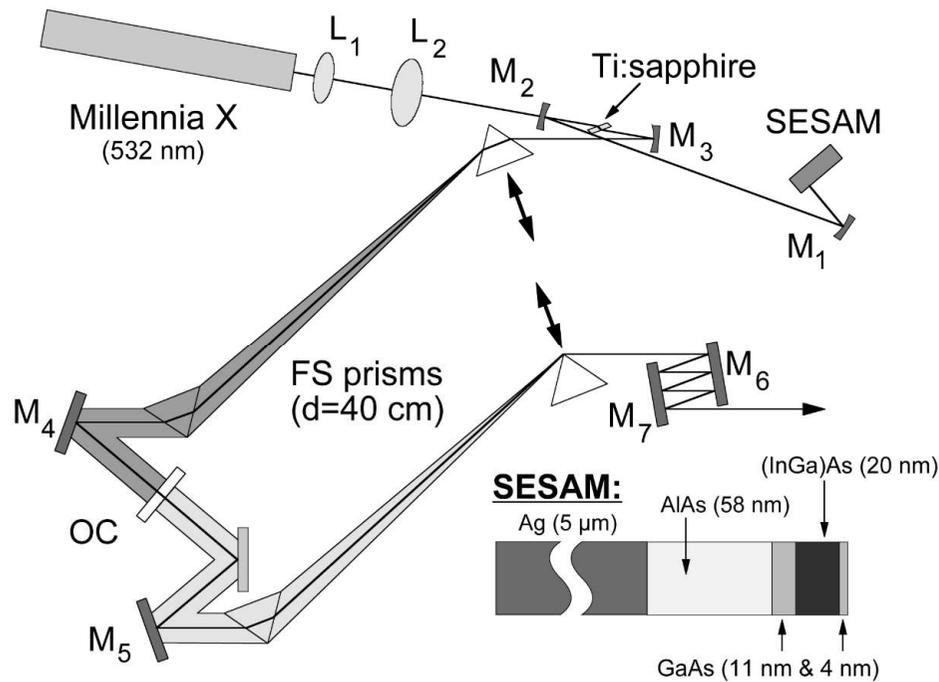


✓ KLM

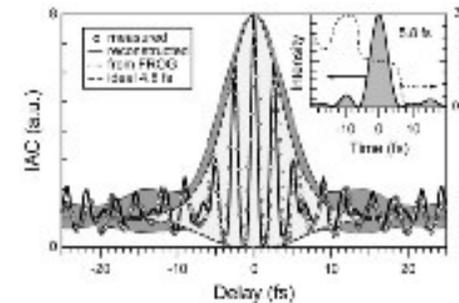
✓ Prisms or chirped mirrors

✓ vibrating mirror or AO or SESAM

Pulses in the two-cycle regime



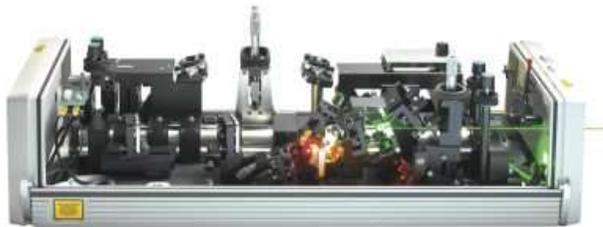
Interferometric autocorrelation



Pulse duration ~ 5 fs

D. H. Sutter, G. Steinmeyer, L. Gallmann, N. Matuschek, F. Morier-Genoud, U. Keller, V. Scheuer, G. Angelow, and T. Tschudi, "Semiconductor saturable-absorber mirror–assisted Kerr-lens mode-locked Ti:sapphire laser producing pulses in the **two-cycle regime**," Opt. Lett. **24**, 631-633 (1999)

Ti:Sapphire commercial lasers



0,7 W, 700-1080 nm, <100fs



0,6 W, 800nm, <8fs

Ti:Sa today :

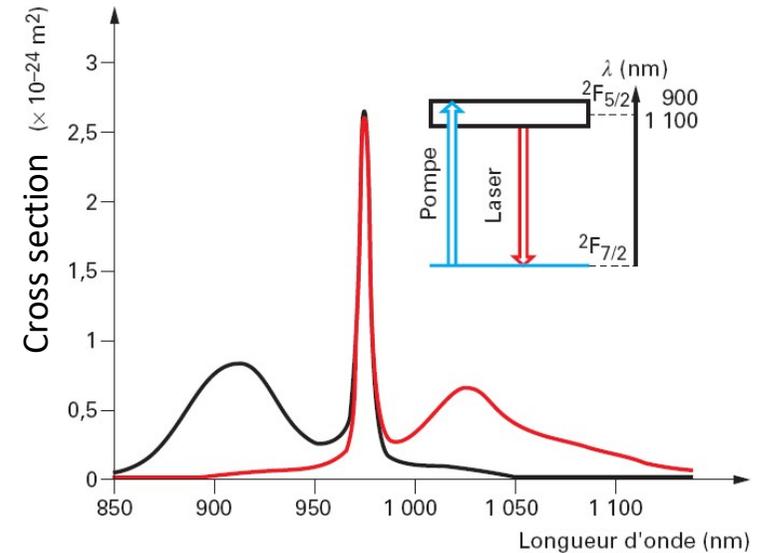
- Expensive and not very effective but reliable, **tunable**, and **very short pulsewidth**
- Many applications : bio-imaging, ultrafast spectroscopy, high field physics, amplifier seeding,...



2,5 W, 690nm- 1020 nm, 140fs

Repetition rate : 80MHz

Ytterbium : bulk oscillator

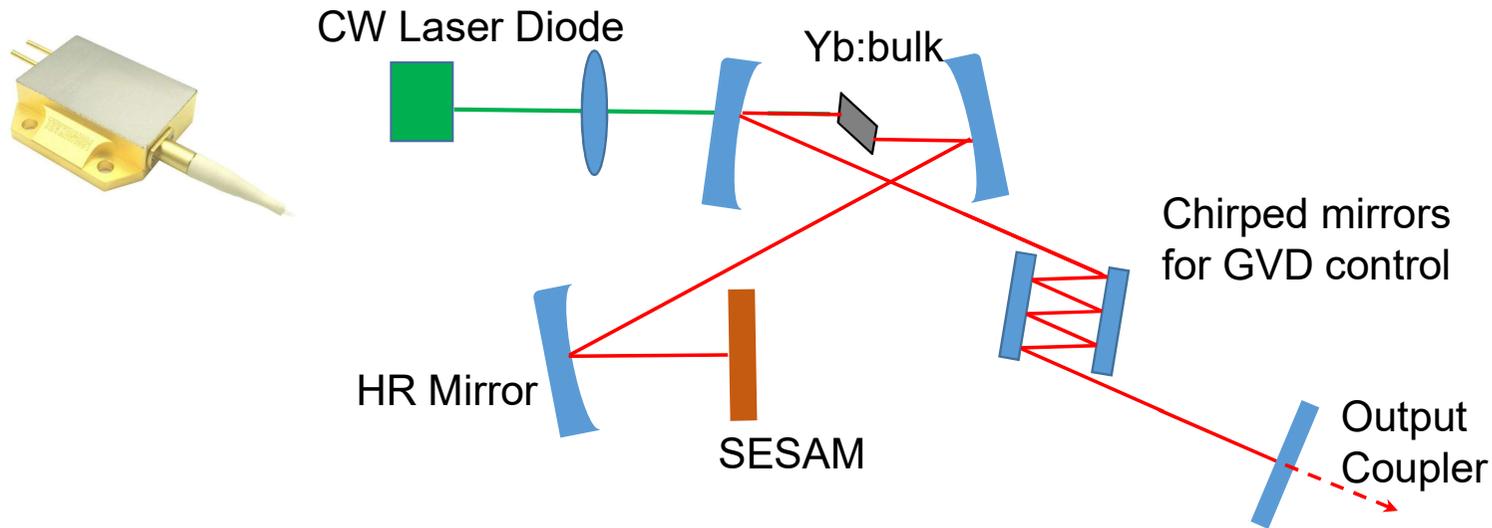


Many different hosts for Ytterbium ions : YAG, glass, KYW, CaF₂, ...

Low quantum defect : high power efficiency, reduced thermal effects

Great advantage : **diode pumping** at 980 nm

Ytterbium : bulk oscillator



Pulse width : 300 fs

Repetition rate : 50 MHz

Energy : a few 100s nJ

High average power

✓ SESAM

✓ Prisms or chirped mirrors

Ytterbium : bulk oscillator



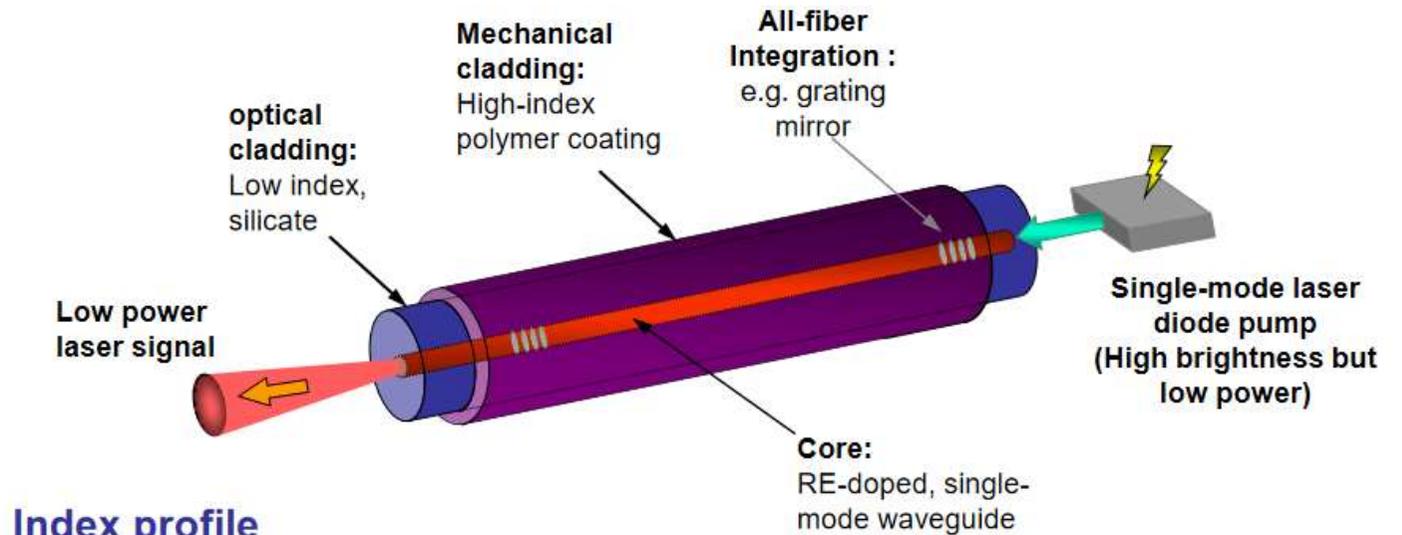
Average Power	> 1,3 W
Energy Per Pulse	> 24 nJ
Pulsewidth	< 250 fs
Repetition Rate	54 MHz
Central Wavelength	1025 +/- 5 nm

Average Power	>1.5 W
Wavelength	1045 ±8.0 nm
Repetition Rate	63 MHz
Pulse Width (FWHM)	<250 fs
Pulse Energy	>24 nJ
Peak Power	>80 kW

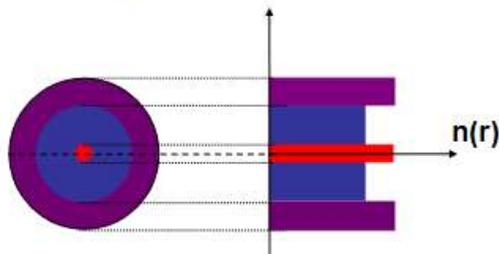
- ✓ High average power
- ✓ Low cost per watt
- ✓ Compact
- ✓ Pulse duration 300fs

Fiber-based oscillators

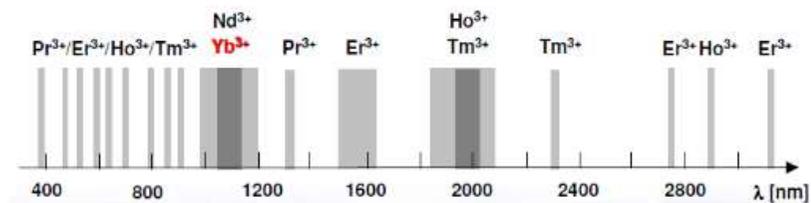
Gain media : fiber doped with Rare Earth ions (Large gain bandwidth)



Index profile

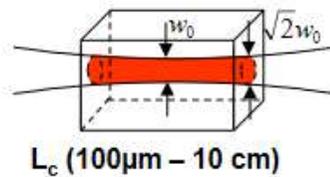
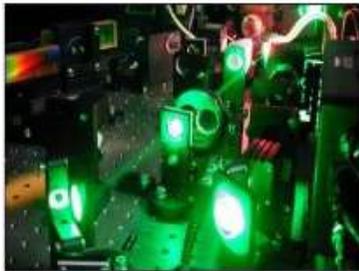


Emission wavelengths of fiber lasers

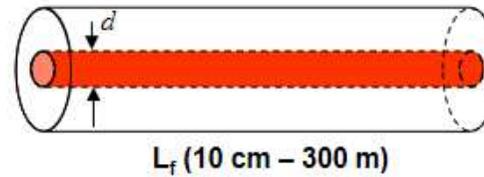


Fiber-based oscillators

Conventional laser



Fibre laser

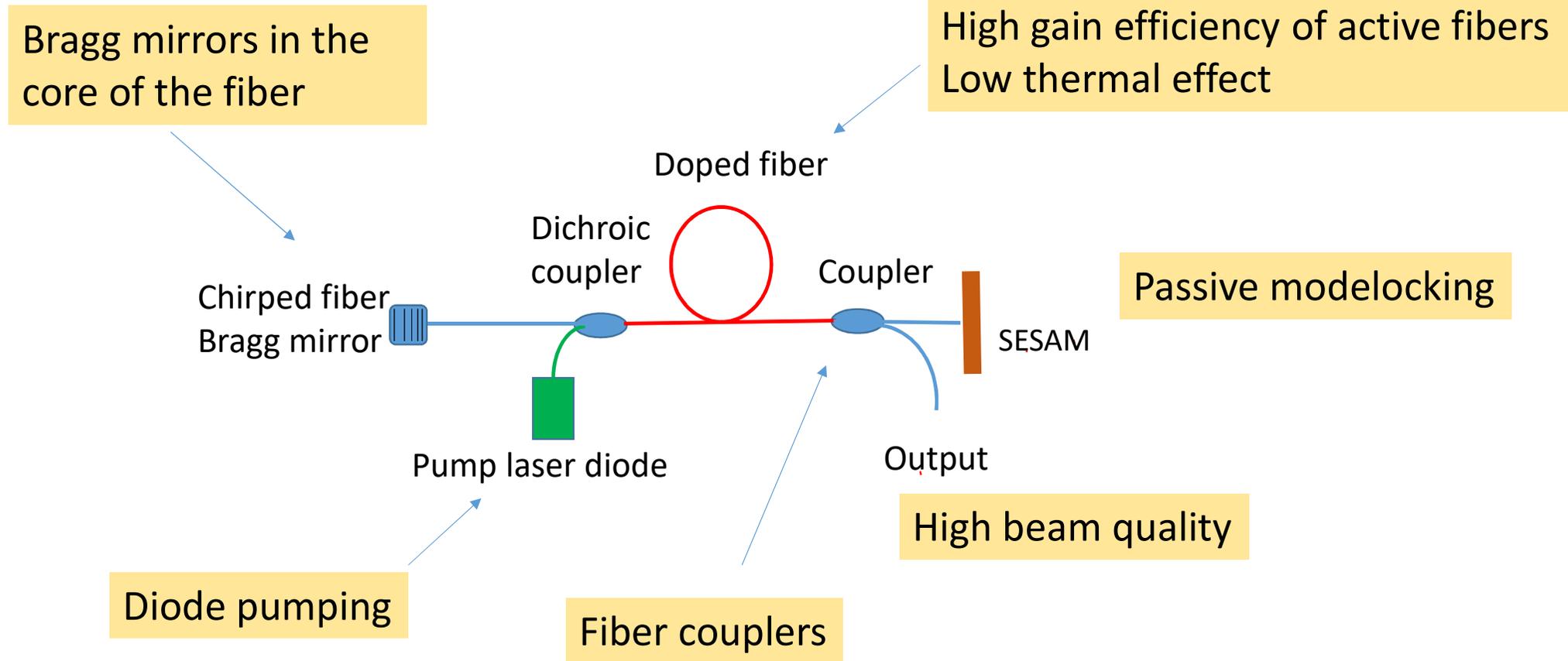


Large surface area
Guided mode
Heat resistance of silica



Low thermal effects

Simple cavity of fiber-based oscillators



Fiber-based oscillators

- ✓ Long propagation distance : High gain, low thermal effects
- ✓ Spatial quality
- ✓ Stability
- ✓ Compactness
- ✓ Cost effective

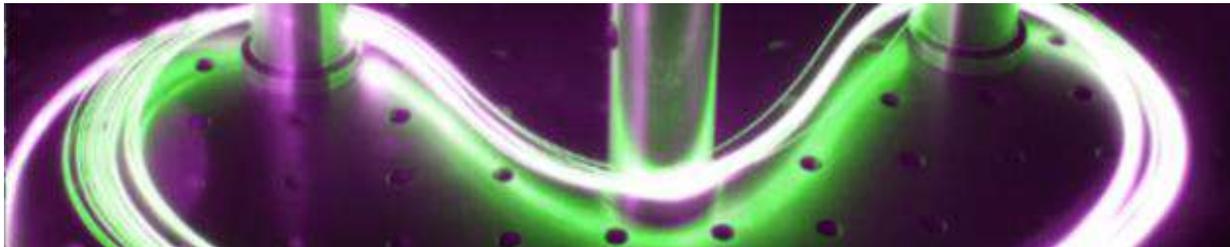
Large variety of designs and specifications



500 mW, 90fs, 1560nm, 100MHz



1 W , 200fs , 1045 nm , 50 MHz
fs pulses delivered by optical cable



© LCF

Summary

- ✓ Ultrashort pulses = broad spectra -> Large dispersion effects
- ✓ Description in both time and frequency domain
- ✓ Generation via modelocking thanks to nonlinear effects
- ✓ Wide variety of femtosecond lasers